


FORM PTO-199 (Modified) (REV 10-95)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTORNEY'S DOCKET NUMBER PE0612	
TRANSMITTAL LETTER TO THE UNITED STATES DESIGNATED/ELECTED OFFICE (DO/EO/US) CONCERNING A FILING UNDER 35 U.S.C. 371				U.S. APPLICATION NO. (IF KNOWN, SEE 37 CFR)	
				09/807298 UNKNOWN	
INTERNATIONAL APPLICATION NO. PCT/US99/25106		INTERNATIONAL FILING DATE 26 OCTOBER 1999 (26.10.1999)		PRIORITY DATE CLAIMED 27 OCTOBER 1998 (27.10.1998)	
TITLE OF INVENTION PHOTORESISTS AND PROCESSES FOR MICROLITHOGRAPHY					
APPLICANT(S) FOR DO/EO/US E. I. DU PONT DE NEMOURS AND COMPANY					
Applicant herewith submits to the United States Designated/Elected Office (DO/EO/US) the following items and other information					
<ol style="list-style-type: none"> 1. <input checked="" type="checkbox"/> This is a FIRST submission of items concerning a filing under 35 U.S.C. 371. 2. <input type="checkbox"/> This is a SECOND or SUBSEQUENT submission of items concerning a filing under 35 U.S.C. 371. 3. <input type="checkbox"/> This is an express request to being national examination procedures (35 U.S.C. 371(f)) at any time rather than delay examination until the expiration of the applicable time limit set in 35 U.S.C. 371(b)) and PCT Articles 22 and 39(1). 4. <input checked="" type="checkbox"/> A proper Demand for International Preliminary Examination was made by the 19th month from the earliest claimed priority date. 5. <input checked="" type="checkbox"/> A copy of the International Application was filed (35 U.S.C. 371 (c) (2)) <ol style="list-style-type: none"> a. <input checked="" type="checkbox"/> is transmitted herewith (required only if not transmitted by the International Bureau. b. <input type="checkbox"/> has been transmitted by the International Bureau. c. <input type="checkbox"/> is not required, as the application was filed in the United States Receiving Office (RO/US) 6. <input type="checkbox"/> A translation of the International Application into English (35 U.S.C. 371 (c) (2)). 7. <input checked="" type="checkbox"/> A copy of the International Search Report (PCT/ISA/210). 8. <input checked="" type="checkbox"/> Amendments to the claims of the International Application under PCT Article 19 (35 U.S.C. 371 (c) (3)) <ol style="list-style-type: none"> a. <input type="checkbox"/> are transmitted herewith (required only if not transmitted by the International Bureau). b. <input type="checkbox"/> have been transmitted by the International Bureau. c. <input type="checkbox"/> have not been made; however, the time limit for making such amendments has NOT expired. d. <input checked="" type="checkbox"/> have not been made and will not be made. 9. <input type="checkbox"/> A translation of the amendments to the claims under PCT Article 19 (35 U.S.C. 371 (c)(3)). 10. <input checked="" type="checkbox"/> An oath or declaration of the inventor(s) (35 U.S.C. 371 (c)(4)). 11. <input checked="" type="checkbox"/> A copy of the International Preliminary Examination Report (PCT/IPEA/409) 12. <input type="checkbox"/> A translation of the annexes to the International Preliminary Examination Report under PCT Article 36 (35 U.S.C. 371 (c)(5)). 					
Items 13 to 18 below concern document(s) or information included :					
<ol style="list-style-type: none"> 13. <input type="checkbox"/> An Information Disclosure Statement under 37 CFR 1.97 and 1.98. 14. <input checked="" type="checkbox"/> An assignment document for recording. A separate cover sheet in compliance with 37 CFR 3.28 and 3.31 is included. 15. <input type="checkbox"/> A FIRST preliminary amendment. A SECOND or SUBSEQUENT preliminary amendment. 16. <input type="checkbox"/> A substitute specification. 17. <input checked="" type="checkbox"/> A change of power of attorney and/or address letter. 18. <input checked="" type="checkbox"/> Certificate of Mailing by Express Mail. 19. <input checked="" type="checkbox"/> Other items or information: 					
<div style="border: 1px solid black; padding: 5px;"> <p>17. General Power of Attorney</p> <p>18. Express Mail Label No.: EF304232754US</p> </div>					

APPLICATION NO. (IF KNOWN, SEE 37 CFR 1.53) UNKNOWN 807298		INTERNATIONAL APPLICATION NO. PCT/US99/25106		ATTORNEY'S DOCKET NUMBER PE0612	
20. The following fees are submitted				CALCULATIONS PTO USE ONLY	
BASIC NATIONAL FEE (37 CFR 1.492 (a) (1) - (5)) :					
<input checked="" type="checkbox"/> Search Report has been prepared by the EPO or JPO \$860.00 <input checked="" type="checkbox"/> International preliminary examination fee paid to USPTO (37 CFR 1.482) \$690.00 <input type="checkbox"/> No international preliminary examination fee paid to USPTO (37 CFR 1.482) but international search fee paid to USPTO (37 CFR 1.445(a)(2)) \$760.00 <input type="checkbox"/> Neither international preliminary examination fee paid to USPTO (37 CFR 1.482) nor international search fee (37 CFR 1.445(a)(2)) paid to USPTO \$1000.00 <input type="checkbox"/> International preliminary examination fee paid to USPTO (37 CFR 1.482) and all claims satisfied provisions of PCT Article 33(2)-(4) \$ 100.00					
ENTER APPROPRIATE BASIC FEE AMOUNT =					
Surcharge of \$130.00 for furnishing the oath or declaration later than months from the earliest claimed priority date (37 CFR 1.492 (e)). <input type="checkbox"/> 20 <input type="checkbox"/> 30				\$0.00	
CLAIMS		NUMBER FILED	NUMBER EXTRA	RATE	
Total Claims		18 - 20 =	0	x \$18.00	\$0.00
Independent Claims		1 - 3 =	0	x \$80.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL OF ABOVE CALCULATIONS =					\$860.00
Reduction of 1/2 for filing by small entity, if applicable. Verified Small Entity Statement must also be filed (Note 37 CFR 1.9, 1.27, 1.28) (check if applicable). <input type="checkbox"/>					\$0.00
SUBTOTAL =					\$860.00
Processing Fee of \$130.00 for furnishing the English translation later than months from the earliest claimed priority date (37 CFR 1.492 (f)). <input type="checkbox"/> 20 <input type="checkbox"/> 30				\$0.00	
TOTAL NATIONAL FEE =					\$860.00
Fee for recording the enclosed assignment (37 CFR 1.21(h)). The assignment must be accompanied by an appropriate cover sheet (37 CFR 3.28, 3.31) (check if applicable). <input type="checkbox"/>					\$40.00
TOTAL FEES ENCLOSED =					\$900.00
					Amount to be refunded \$
					Charged \$
<input type="checkbox"/> A check in the amount of _____ to cover the above fees enclosed. <input checked="" type="checkbox"/> Please charge my Deposit Account No. 04-1928 in the amount of \$900.00 to cover the above fees. <input checked="" type="checkbox"/> The Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment to Deposit Account No. 04-1928 a duplicate copy of this sheet is enclosed.					
NOTE : Where an appropriate time limit under 37 CFR 1.494 or 1.495 has not been met, a petition to revive (CFR 1.37(a) or (b)) must be filed and granted to restore the application to pending status. SEND ALL CORRESPONDENCE TO:					
<div style="display: flex; justify-content: space-between;"> <div style="width: 40%;"> SINNOTT, Jessica M. E. I. DU PONT DE NEMOURS AND COMPANY Legal Patent Records Center 1007 Market Street Wilmington, Delaware 19898 United States of America </div> <div style="width: 55%;"> <div style="text-align: center;">  SIGNATURE BOWMAN, ROGER A., FOR SINNOTT, JESSICA M. NAME 34,015 REGISTRATION NUMBER DATE </div> </div> </div>					

TITLEPHOTORESISTS AND PROCESSES FOR MICROLITHOGRAPHYBACKGROUND OF THE INVENTION

1. Field of The Invention

5 The present invention pertains to photoimaging and to the use of positive-working photoresists, particularly for imaging in the production of semiconductor devices.

2. Description of Related Art

10 Polymer products are used as components of imaging and photosensitive systems and particularly in photoimaging systems such as those described in Introduction to Microlithography, Second Edition by L. F. Thompson, C. G. Willson, and M. J. Bowden, American Chemical Society, Washington, DC, 1994. In such systems, ultraviolet (UV) light or other electromagnetic radiation impinges on a material containing a photoactive component to induce a physical
15 or chemical change in that material. An image or latent image is thereby produced which can be used for semiconductor device fabrication.

Although the polymer product itself may be photoactive, generally a photosensitive composition contains one or more photoactive components in addition to the polymer product. Upon exposure to electromagnetic radiation
20 (e.g., UV light), the photoactive component acts to change the rheological state, the solubility, the surface characteristics, refractive index, the color, the electromagnetic characteristics or other such physical or chemical characteristics of the photosensitive composition as described in the Thompson et al. publication supra.

25 For imaging very fine features at the submicron (sub- μm) level in semiconductor devices, electromagnetic radiation in the deep or vacuum ultraviolet (UV) is typically employed. Positive working resists generally are utilized for semiconductor manufacture. Lithography in the violet or the UV at 365 nm (I-line) using novolak polymers and diazonaphthoquinones as dissolution
30 inhibitors is a currently established chip technology having a resolution limit of about 0.35-0.30 μm . Lithography in the deep UV (DUV) at 248 nm using p-hydroxystyrene polymers is known and has a resolution limit of 0.35-0.18 μm . There is strong impetus for future photolithography at even shorter wavelengths, due to decreasing lower resolution limit with decreasing wavelength (i.e., a
35 resolution limit of 0.18-0.13 μm for 193 nm imaging). Photolithography using 193 nm exposure wavelength (obtained from an argon fluorine (Ar-F) excimer laser) is a leading candidate for future microelectronic fabrication using 0.18 and 0.13 μm design rules. Photolithography using 157 nm exposure wavelength

(obtained using an F₂ laser source) may be used for future microelectronics fabrication using 0.100 μm or less design rules. The opacity of traditional UV and deep-UV organic photoresists at 193 nm precludes their use in single-layer schemes at this wavelength. Recently new photoresist compositions comprising cycloolefin-maleic anhydride alternating copolymers have been shown to be useful for imaging of semiconductors at 193 nm (see F. M. Houlihan et al., Macromolecules, **30**, pages 6517-6534 (1997); T. Wallow et al., SPIE, Vol. 2724, pages 355-364; and F. M. Houlihan et al., Journal of Photopolymer Science and Technology, **10**, No. 3, pages 511-520 (1997)).

- Comb polymers are a particular class of branched polymers wherein one or more branch (polymer) segments are linked along a linear (polymer) backbone segment. Comb polymers may also be described as linear polymers with polymeric arms. Such polymers typically are prepared by copolymerizing a conventional monomer with a macromer. Macromers are defined by Kawakami in the "Encyclopedia Of Polymer Science And Engineering", Vol. 9, pp. 195-204 (John Wiley & Sons, New York, 1987) to be polymers of molecular weight ranging from several hundred to tens of thousands, with a functional group at the end that can further polymerize, such as an ethylenic, an epoxy, a dicarboxylic acid, a diol or a diamino group. U.S. Patent 5,061,602 discloses the use of such a polymer as a binding agent in a negative-working photopolymerizable material suitable for producing printing forms or resist patterns. The polymer binder disclosed consists of a film-forming copolymer that has a multi-phase morphology where at least one phase has a glass transition temperature below room temperature and at least one other phase has a glass transition temperature above room temperature. The copolymer has an average molecular weight (weight average) of more than 10,000, and is produced using an ethylenically unsaturated macromer with an average molecular weight (weight average) of 1000 to 100,000. The use of graft (comb) copolymers having acid functionality in certain negative-working photosensitive compositions, such as solder masks, has published (see PCT International Publication No. WO92/15628).

- M. Yamana et al., Deblocking Reaction of Chemically Amplified ArF Positive Resists, PROC. SPIE - INT. SOC. OPT. ENG., Vol. 3333, No. 1, pages 32-42 (June 1998) discloses deblocking reaction mechanisms and lithographic performance in chemically amplified positive ArF resists consisting of triphenylsulfonium triflate as an acid generator and the copolymer poly(carboxy-tetracyclododecyl methacrylate-co-tetrahydropyranilcarboxy-tetracyclododecyl methacrylate)₃₀. EP 0 473 547 A (CIBA-GEIGY AG 4 March 1992) discloses certain olefinically unsaturated onium salts which can be polymerized and used as

photosensitive copolymers in photoresist compositions. The photosensitive copolymers disclosed include branch copolymers containing protected acid groups and acid-generating groups.

There is a critical need though for other novel resist compositions for use
5 at 193 nm or lower, and particularly at 157 nm, that have not only high
transparency at these short wavelengths but also other suitable key properties,
including good plasma etch resistance and adhesive properties. This invention
addresses this critical need by providing new advantageous compositions and
associated processes, comprising graft (comb) copolymers, which have these key
10 properties.

SUMMARY OF THE INVENTION

The present invention comprises:

(A) a branched polymer containing protected acid groups, said polymer comprising one or more branch segment(s) chemically linked along a linear backbone segment, wherein the branch segment(s) contain at least two repeating monomer units and have a number average molecular weight (M_n) of at least 1000.

(B) at least one photoacid generator.

In another embodiment, the invention is a positive photoresist as described supra wherein the photoacid generator is covalently bonded to the branched polymer.

The invention also includes a process for preparing a photoresist image on a substrate comprising, in order:

(W) applying a photoresist composition on a substrate, wherein the photoresist composition comprises:

(a) a branched polymer containing protected acid groups, said polymer comprising one or more branch segment(s) chemically linked along a linear backbone segment, wherein the branched polymer contains sufficient functionality to render the photoresist developable to afford a relief image, upon imagewise exposure to violet or ultraviolet radiation and subsequent heating, and wherein the branch segment(s) contain at least two repeating monomer units and have a number average molecular weight (M_n) of at least 1000;

(b) at least one photoacid generator; and

(c) a solvent;

(X) drying the coated photoresist composition to remove solvent and thereby to form a photoresist layer on the substrate;

(Y) imagewise exposing the photoresist layer to form imaged and non-imaged areas; and

(Z) developing the exposed photoresist layer having imaged and non-imaged areas to form the relief image on the substrate.

The photoresist compositions of this invention have a particularly good balance of desirable properties, including high transparency to near, far, and extreme ultraviolet light, high plasma etch resistance, and projected high resolution characteristics suitable for microelectronic device fabrication.

BRIEF DESCRIPTION OF THE DRAWINGS

Figure 1 is a plot of absorbance (μm^{-1}) versus wavelength (nm) in the UV region for corresponding random, block, and graft copolymers having the same or similar comonomer compositions.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENT(S)

Each photosensitive composition of this invention contains a branched polymer, also known as a comb polymer, which contains protected acid groups. The branched polymer has branch segments, known as polymer arms, of limited
5 molecular weight and limited weight ratio relative to a linear backbone segment.

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- In a preferred embodiment, a majority of the protected acid groups are present in the branch segments. The composition also contains a component, such as a photoacid generator, which renders the composition reactive to radiant energy, especially to radiant energy in the ultraviolet region of the electromagnetic spectrum and most especially in the far or extreme ultraviolet region.

BRANCHED POLYMER

- The branched polymer that is a component in each photosensitive composition of this invention contains protected acid groups and comprises one or more branch segment(s) chemically linked along a linear backbone segment. The branched polymer can be formed during free radical addition polymerization of at least one ethylenically unsaturated macromer component and at least one ethylenically unsaturated comonomer. The ethylenically unsaturated macromer component has a number average molecular weight (M_n) between a few hundred and 40,000 and the linear backbone segment resulting from the polymerization has a number average molecular weight (M_n) between about 2,000 and about 500,000. The weight ratio of the linear backbone segment to the branch segment(s) is within a range of about 50/1 to about 1/10, and preferably within the range of about 80/20 to about 60/40. Preferably the macromer component has a number average molecular weight (M_n) from 500 to about 40,000 and more preferably of about 1,000 to about 15,000. Typically such an ethylenically unsaturated macromer component can have a number average molecular weight (M_n) equivalent to there being from about 2 to about 500 monomer units used to form the macromer component and preferably between 30 and 200 monomer units.

- In a preferred embodiment, the branched polymer contains from 25% to 100% by weight of compatibilizing groups, i.e., functional groups present to increase compatibility with the photoacid generator, preferably from about 50% to 100% by weight, and more preferably from about 75% to 100% by weight. Suitable compatibilizing groups for ionic photoacid generators include, but are not limited to, both non-hydrophilic polar groups and hydrophilic polar groups. Suitable non-hydrophilic polar groups include, but are not limited to, cyano (-CN) and nitro (-NO₂). Suitable hydrophilic polar groups include, but are not limited to protic groups such as hydroxy (OH), amino (NH₂), ammonium, amido, imido, urethane, ureido, or mercapto; or carboxylic (CO₂H), sulfonic, sulfinic, phosphoric, or phosphoric acids or salts thereof. Preferably, compatibilizing groups are present in the branch segment(s).

Preferably, the protected acid groups (described *infra*) produce carboxylic acid groups after exposure to UV or other actinic radiation and subsequent post-exposure baking (i.e., during deprotection). The branched polymer present in the

photosensitive compositions of this invention, typically will contain between about 3% to about 40% by weight of monomer units containing protected acid groups, preferably between about 5% to about 50%, and more preferably between about 5% to about 20%. The branch segments of such a preferred branched
5 polymer typically contain between 35% to 100% of the protected acid groups present. Such a branched polymer when completely unprotected (all protected acid groups converted to free acid groups) has an acid number between about 20 and about 500, preferably between about 30 and about 330, and more preferably between about 30 and about 130, and analogously the ethylenically unsaturated
10 macromer component preferably has an acid number of about 20 and about 650, more preferably between about 90 and about 300 and the majority of the free acid groups are in the branch segments.

In a specific embodiment, the branched polymer comprises one or more branch segments chemically linked along a linear backbone segment wherein the
15 branched polymers have a number average molecular weight (M_n) of about 500 to 40,000. The branched polymer contains at least 0.5% by weight of branch segments. The branch segments, also known as polymer arms, typically are randomly distributed along the linear backbone segment. The "polymer arm" or branch segment is a polymer or oligomer of at least two repeating monomer units,
20 which is attached to the linear backbone segment by a covalent bond. The branch segment, or polymer arm, can be incorporated into the branched polymer as a macromer component, during the addition polymerization process of a macromer and a comonomer. A "macromer" for the purpose of this invention, is a polymer, copolymer or oligomer of molecular weight ranging from several hundred to about
25 40,000 containing a terminal ethylenically unsaturated polymerizable group. Preferably the macromer is a linear polymer or copolymer end capped with an ethylenic group. Typically, the branched polymer is a copolymer bearing one or more polymer arms, and preferably at least two polymer arms, and is characterized in that between about 0.5 and about 80 weight %, preferably between about 5 and
30 50 weight % of the monomeric components used in the polymerization process is a macromer. Typically, comonomer components used along with the macromer in the polymerization process likewise contain a single ethylenic group that can copolymerize with the ethylenically unsaturated macromer.

The ethylenically unsaturated macromer and the resulting branch segment
35 of the branched polymer, and/or the backbone of the branched polymer, can have bonded thereto one or more protected acid groups. For the purposes of this invention, a "protected acid group" means a functional group which, when deprotected, affords free acid functionality that enhances the solubility,

swellability, or dispersibility in aqueous environments, of the macromer and/or the branched polymer to which it is bonded. The protected acid group may be incorporated into the ethylenically unsaturated macromer and the resulting branch segment of the branched polymer, and/or the backbone of the branched polymer, either during or after their formation. While addition polymerization using a macromer and at least one ethylenically unsaturated monomer is preferred for forming the branched polymer, all known methods of preparing branched polymers using either addition or condensation reactions can be utilized in this invention. Furthermore, use of either preformed backbones and branch segments or in situ polymerized segments are also applicable to this invention.

The branch segments attached to the linear backbone segment can be derived from ethylenically unsaturated macromers prepared according to the general descriptions in U.S. Patent 4,680,352 and U.S. Patent 4,694,054. Macromers are prepared by free radical polymerization processes employing a cobalt compound as a catalytic chain transfer agent and particularly a cobalt(II) compound. The cobalt(II) compound may be a pentacyanocobalt(II) compound or a cobalt(II) chelate of a vicinal iminobis(hydroxyimino) compound, a dihydroxyimino compound, a diazadihydroxyiminodialkyldecadiene, a diazadihydroxyiminodialkylundecadiene, a tetraazatetraalkylcyclotetradecatetraene, a tetraazatetraalkylcyclododecatetraene, a bis(difluoroboryl) diphenyl glyoximate, a bis(difluoroboryl) dimethyl glyoximate, a N,N'-bis(salicylidene)ethylenediamine, a dialkylidiazadioxodialkyldecadiene, or a dialkylidiazadioxodialkyltridecadiene. Low molecular weight methacrylate macromers may also be prepared with a pentacyanocobalt(II) catalytic chain transfer agent as disclosed in U.S. Patent 4,722,984.

Illustrative macromers using this approach are methacrylate polymers with acrylates or other vinyl monomers wherein the polymers or copolymers have a terminal ethylenic group and a hydrophilic functional group. Preferred monomer components for use in preparing macromers include: tertiary-butyl methacrylate (tBMA), tertiary-butyl acrylate (tBA), methyl methacrylate (MMA); ethyl methacrylate (EMA); butyl methacrylate (BMA); 2-ethylhexyl methacrylate; methyl acrylate (MA); ethyl acrylate (EA); butyl acrylate (BA); 2-ethylhexyl acrylate; 2-hydroxyethyl methacrylate (HEMA); 2-hydroxyethyl acrylate (HEA); methacrylic acid (MA); acrylic acid (AA); esters of acrylic and methacrylic acid wherein the ester group contains from 1 to 18 carbon atoms; nitriles and amides of acrylic and methacrylic acid (e.g., acrylonitrile); glycidyl methacrylate and acrylate; itaconic acid (IA) and itaconic acid anhydride (ITA), half ester and imide; maleic acid and maleic acid anhydride, half ester and imide; aminoethyl

methacrylate; t-butyl aminoethyl methacrylate; dimethyl aminoethyl methacrylate; diethyl aminoethyl methacrylate; aminoethyl acrylate; dimethyl aminoethyl acrylate; diethyl aminoethyl acrylate; acrylamide; N-t-octyl acrylamide; vinyl methyl ether; styrene (STY); alpha-methyl styrene (AMS); vinyl acetate; vinyl chloride; and the like.

Itaconic acid anhydride (ITA, 2-methylenesuccinic anhydride, CAS No. = 2170-03-8) is a particularly advantageous comonomer for use in the branched polymer since it has two active functional groups in the anhydride form, which become three upon ring opening to afford diacid. The ethylenically unsaturated moiety is a first functional group, which provides capability for this comonomer to be incorporated into a copolymer by, for example, free radical polymerization. The anhydride moiety is a second functional group that is capable of reacting with a variety of other functional groups to afford covalently bonded products. An example of a functional group that an anhydride moiety can react with is a hydroxy group in an alcohol to form an ester linkage. Upon reaction of the anhydride moiety of ITA with a hydroxy group, there is formed an ester linkage and a free carboxylic acid moiety, which is a third functional group. The carboxylic acid functional group is useful in imparting aqueous processability to the resists of this invention. If a PAG is utilized having a hydroxy group, it is possible, as illustrated in some of the examples, to covalently link (tether) a PAG (or other photoactive components) to a branched polymer comprised of ITA comonomer or the like via this type of ester linkage (or other covalent linkages, such as amide, etc.).

The branched polymer may be prepared by any conventional addition polymerization process. The branched polymer, or comb polymer, may be prepared from one or more compatible ethylenically unsaturated macromer components and one or more compatible, conventional ethylenically unsaturated comonomer component(s). Preferred addition polymerizable, ethylenically unsaturated comonomer components are acrylates, methacrylates, and styrenics as well as mixtures thereof. Suitable addition polymerizable, ethylenically unsaturated comonomer components include: tertiary-butyl methacrylate (tBMA), tertiary-butyl acrylate (tBA), methyl methacrylate (MMA); ethyl methacrylate (EMA); butyl methacrylate (BMA); 2-ethylhexyl methacrylate; methyl acrylate (MA); ethyl acrylate (EA); butyl acrylate (BA); 2-ethylhexyl acrylate; 2-hydroxyethyl methacrylate (HEMA); 2-hydroxyethyl acrylate (HEA); methacrylic acid (MAA); acrylic acid (AA); acrylonitrile (AN); methacrylonitrile (MAN); itaconic acid (IA) and itaconic acid anhydride (ITA), half ester and imide; maleic acid and maleic acid anhydride, half ester and imide; aminoethyl

methacrylate; t-butyl aminoethyl methacrylate; dimethyl aminoethyl methacrylate; diethyl aminoethyl methacrylate; aminoethyl acrylate; dimethyl aminoethyl acrylate; diethyl aminoethyl acrylate; acrylamide; N-t-octyl acrylamide; vinyl methyl ethers; styrene (S); alpha-methyl styrene; vinyl acetate; vinyl chloride; and the like. The majority of the copolymerizable monomer must be acrylate or styrenic or copolymers of these monomers with acrylates and other vinyl monomers.

Each constituent linear backbone segment and/or branch segment of the branched polymer of this invention may contain a variety of functional groups. A "functional group" is considered to be any moiety capable of being attached to a backbone segment or a branch segment by a direct valence bond or by a linking group. Illustrative of functional groups which can be borne by the backbone segment or the branch segments are -COOR; -OR; -SR (where R can be hydrogen, alkyl or cycloalkyl of 1-12 carbon atoms, aryl, alkaryl or aralkyl, a heterocyclic, or -OR₁ where R₁ can be alkyl of 1-12 carbon

atoms, aryl, alkaryl or aralkyl); -CN; -NR₂R₃ or $\text{---}\overset{\text{O}}{\parallel}\text{---NR}_2\text{R}_3$ (where R₂ and R₃ can be hydrogen, alkyl or cycloalkyl of 1-12 carbon atoms, aryl, alkaryl, aralkyl, -CH₂OR₄ (where R₄ is hydrogen, alkyl or cycloalkyl of 1-12 carbon atoms, aryl, alkaryl, aralkyl), or together R₂ and R₃ can form a heterocyclic ring);

$\text{---}\overset{\text{R}_5}{\underset{|}{\text{C}}}=\text{CR}_6\text{R}_7$ (where R₅, R₆ and R₇ can be hydrogen, alkyl or cycloalkyl of 1-12 carbon atoms, aryl, alkaryl, aralkyl, or -COOR or when taken together R₅, R₆ and/or R₇ can form a cyclic group); -SO₃H; a urethane group; an isocyanate or blocked isocyanate group; a urea group; an oxirane group; an aziridine group; a quinone diazide group; an azo group; an azide group; a diazonium group; an acetylacetoxy group; -SiR₈R₉R₁₀ (where R₈, R₉ and R₁₀ can be alkyl or cycloalkyl of 1-12 carbon atoms or -OR₁₁ where R₁₁ is alkyl or cycloalkyl of 1-12 carbon atoms, aryl, alkaryl or aralkyl); or an -OSO₃R₁₂, -OPO₂R₁₂, -PO₂R₁₂, -PR₁₂R₁₃R₁₄, -OPOR₁₂, -SR₁₂R₁₃, or -N+R₁₂R₁₃R₁₄ group (where R₁₂, R₁₃ and R₁₄ can be hydrogen, alkyl or cycloalkyl of 1-12 carbon atoms, aryl, alkaryl or aralkyl); or a salt or onium salt of any of the foregoing. Preferred functional groups are -COON, -OH, -NH₂, an amide group, a vinyl group, a urethane group, an isocyanate group, a blocked isocyanate group or combinations thereof. Functional groups may be located anywhere on the branched polymer. However, it is sometimes desirable to choose comonomers which impart bulk polymer characteristics to the linear backbone segment of the branched polymer and

macromers which impart physical and chemical functionality to the branch segments in addition to hydrophilicity, such as solubility, reactivity, and the like.

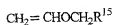
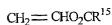
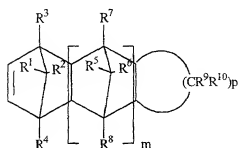
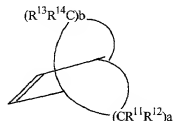
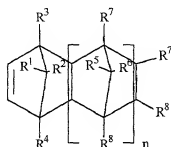
In certain preferred embodiments of this invention, the branched polymer contains functional groups that are compatible with the photoacid generator, said functional groups being distributed in the branched polymer such that 25 to 100% of the functional groups are present in the segment of the branched polymer containing a majority of the protected acid groups. These functional groups are desirable since having enhanced compatibility of the photoacid generator with the branched polymer segmented having the majority of protected acid groups results in higher photospeed and perhaps higher resolution and/or other desirable properties of resists comprised of these branched polymer(s) having these functional groups to promote compatibility. For an ionic PAG, such as a triarylsulfonium salt, functional groups that promote compatibility include, but are not limited to, polar non-hydrophilic groups (e.g., nitro or cyano) and polar hydrophilic groups (e.g., hydroxy, carboxyl). For a nonionic PAG, such as structure III *infra*, preferred functional groups for imparting compatibility are less polar than the polar groups listed above. For the latter case, suitable functional groups include, but are not limited to, groups which impart rather similar chemical and physical properties to those of the non-ionic PAG. As two specific examples, aromatic and perfluoroalkyl functional groups are effective in promoting compatibility of the branched polymer with a nonionic PAG, such as structure III given *infra*.

In some preferred embodiments, the branched polymer is an acrylic/methacrylic/styrenic copolymer being at least 60% by weight acrylate and having at least 60% of methacrylate repeat units present either in a first location or a second location, the first location being one of the segments (i.e., branch segment(s) or linear backbone segment), the second location being a segment different from the first location, wherein at least 60% of the acrylate repeat units are present in the second location.

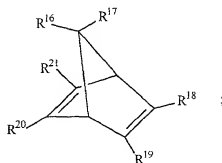
In some embodiments, the branched polymer is a fluorine-containing graft copolymer comprising a repeat unit derived from at least one ethylenically unsaturated compound containing at least one fluorine atom covalently attached to an ethylenically unsaturated carbon atom. The repeat unit bearing at least one fluorine atom can be either in the linear polymer backbone segment or in the branch polymer segment(s); preferably, it is in the linear polymer backbone segment. Representative ethylenically unsaturated compounds that are suitable for the fluorine-containing graft copolymers of this invention include, but are not limited to, tetrafluoroethylene, chlorotrifluoroethylene, hexafluoropropylene,

trifluoroethylene, vinylidene fluoride, vinyl fluoride, and $R_f\text{OCF}=\text{CF}_2$ wherein R_f is a saturated perfluoroalkyl group of from 1 to about 10 carbon atoms. The fluorine-containing copolymers of this invention can be comprised of any integral number of additional fluorine-containing comonomers, which include, but are not
5 limited to, those listed supra. Preferred comonomers are tetrafluoroethylene, chlorotrifluoroethylene, hexafluoropropylene, trifluoroethylene and $R_f\text{OCF}=\text{CF}_2$, wherein R_f is a saturated perfluoroalkyl group of from 1 to about 10 carbon atoms. More preferred comonomers are tetrafluoroethylene, chlorotrifluoroethylene, hexafluoropropylene, and $R_f\text{OCF}=\text{CF}_2$, wherein R_f is a saturated perfluoroalkyl
10 group of from 1 to about 10 carbon atoms. Most preferred comonomers are tetrafluoroethylene and chlorotrifluoroethylene.

In some preferred embodiments, the fluorine-containing graft copolymer is further comprised of a repeat unit derived from at least one unsaturated compound selected from the group consisting of:



and



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wherein:

each of m and n is 0, 1 or 2, p is an integer of at least 3;

a and b are independently 1 to 3 except that a is not = 1 when b = 2 or vice

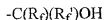
10 versa;

R¹ to R¹⁴ are the same or different and each represents a hydrogen atom, a halogen atom, a carboxyl group, a C₁ to C₁₄ secondary or tertiary alkyl carboxylate, a hydrocarbon group or a substituted hydrocarbon group;

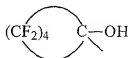
R¹⁵ is a saturated alkyl group of about 4 to 20 carbon atoms, optionally containing one or more ether oxygens with the proviso that the ratio of carbon atoms to hydrogen atoms is greater than or equal to 0.58; and

- R¹⁶ to R²¹ are each independently hydrogen atoms, C₁ to C₁₂ alkyls, (CH₂)_qCO₂A, CO₂(CH₂)_qCO₂A or CO₂A wherein q is 1 to 12 and A is hydrogen or an acid protecting group with the proviso that at least one of R¹⁸ to R²¹ is CO₂A. In one embodiment of this invention, a PAG is covalently linked (i.e., tethered) to the fluorine-containing graft copolymer to afford a photoresist.

- In some preferred embodiments, the branched polymer is a fluorine-containing copolymer comprising a repeat unit derived from at least one ethylenically unsaturated compound containing a fluoroalcohol functional group having the structure:



- wherein R_f and R_f' are the same or different fluoroalkyl groups of from 1 to about 10 carbon atoms or taken together are (CF₂)_n wherein n is 2 to 10. A given fluorine-containing branched copolymer comprising a repeat unit derived from at least one ethylenically unsaturated compound containing a fluoroalcohol functional group according to this invention can have fluoroalkyl groups present as part of the fluoroalcohol functional group. These fluoroalkyl groups are designated as R_f and R_f', which can be partially fluorinated alkyl groups or fully fluorinated alkyl groups (i.e., perfluoroalkyl groups). Broadly, R_f and R_f' are the same or different fluoroalkyl groups of from 1 to about 10 carbon atoms or taken together are (CF₂)_n wherein n is 2 to 10. (In the last sentence, the terms "taken together" indicate that R_f and R_f' are not separate, discrete fluorinated alkyl groups, but that together they form a ring structure such as is illustrated below in case of a 5-membered ring:



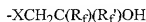
- R_f and R_f' can be partially fluorinated alkyl groups without limit according to the invention except that there must be a sufficient degree of fluorination present to impart acidity to the hydroxyl (-OH) of the fluoroalcohol functional group, such that the hydroxyl proton is substantially removed in basic media, such as in aqueous sodium hydroxide solution or tetraalkylammonium hydroxide solution.

In preferred cases according to the invention, there will be sufficient fluorine substitution present in the fluorinated alkyl groups of the fluoroalcohol functional group such that the hydroxyl group will have a pKa value as follows: $5 < \text{pKa} < 11$. Preferably, R_f and R_f' are independently perfluoroalkyl group of 1 to 5 carbon

atoms, and, most preferably, R_f and R_f' are both trifluoromethyl (CF_3).

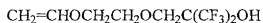
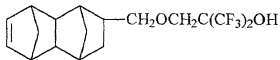
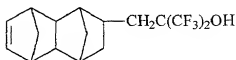
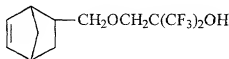
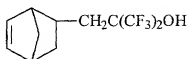
Preferably, each fluorine-containing copolymer according to this invention has an absorption coefficient of less than $4.0 \mu\text{m}^{-1}$ at a wavelength of 157 nm, preferably of less than $3.5 \mu\text{m}^{-1}$ at this wavelength, and, more preferably, of less than $3.0 \mu\text{m}^{-1}$ at this wavelength.

The fluorinated polymers, photoresists, and processes of this invention that involve a fluoroalcohol functional group may have the structure:



wherein R_f and R_f' are the same or different fluoroalkyl groups of from 1 to about 10 carbon atoms or taken together are $(\text{CF}_2)_n$ wherein n is 2 to 10; X is selected from the group consisting of oxygen, sulfur, nitrogen, phosphorous, other Group Va element, and other Group VIa element. By the terms "other Group Va element" and "other Group VIa element", these terms are understood to mean herein any other element in one of these groups of the periodic table that is other than the recited elements (i.e., oxygen, sulfur, nitrogen, phosphorous) in these groups. Oxygen is the preferred X group.

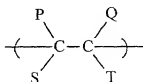
Some illustrative, but nonlimiting, examples of representative comonomers containing a fluoroalcohol functional group and within the scope of the invention are presented below:



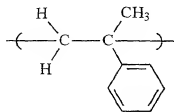
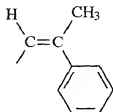
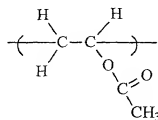
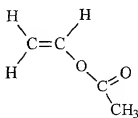
As is well known to those skilled in the polymer art, an ethylenically unsaturated compound undergoes free radical polymerization to afford a polymer having a repeat unit that is derived from the ethylenically unsaturated compound. Specifically, an ethylenically unsaturated compound having structure:



that undergoes free radical polymerization will afford a polymer having a repeat unit:



where P, Q, S, and T independently can represent, but are not limited to, H, F, Cl, Br, CO_2R_e ($\text{R}_e = \text{C}_1\text{-C}_{12}$ alkyl), alkyl, aryl, aralkyl and cycloalkyl. If only one ethylenically unsaturated compound undergoes polymerization, the resulting polymer is a homopolymer. If two or more distinct ethylenically unsaturated compounds undergo polymerization, the resulting polymer is a copolymer. Some representative examples of ethylenically unsaturated compounds and their corresponding repeat units are given below:



PHOTOSENSITIVE COMPOSITIONS

The branched polymers are particularly useful in photosensitive compositions containing at least one photoactive component and in particular in photosensitive compositions, such as lithographic photoresists and the like, which will be further described to illustrate this invention. "Photoactive", which is synonymous with "photosensitive", describes a material which changes its chemical or physical nature, or causes such a change, upon exposure to actinic radiation, in such a way that the change is formed directly, e.g., an image, or that a precursor, e.g., a latent image, is formed which upon further treatment produces the desired change. Illustrative of such a photoactive component is a material which cyclizes, dimerizes, polymerizes, crosslinks, generates a free radical, generates an acid or other ionic species or dissociates upon exposure to actinic radiation (e.g., UV light). A photoactive or photosensitive component includes a photoinitiator, a photosensitizer or a combination thereof; a photoacid generator (PAG), a photosolubilizer; a photodesensitizer; a photoinhibitor; a phototackifier; a photodetackifier; or a component which is photodegradable; photochromic; photoreducible; photooxidizable; photoadhesive; photoreleaseable; photomagnetic; photodemagnetic; photoconductive or photoinsulative; or is a material which changes or causes changes in refractive index upon exposure to actinic radiation. The photosensitive compositions of this invention include those instances in which component (B) is bonded to component (A); or in which component (B) has greater compatibility with the segment of the branched polymer that contains the major portion of acid protected groups.

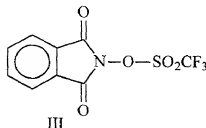
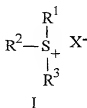
The branched polymers are useful as components of photosensitive systems and particularly in photoimaging systems such as those described in Introduction to Microlithography, Second Edition by L. F. Thompson, C. G. Willson, and M. J. Bowden, American Chemical Society, Washington, DC, 1994. In such systems, actinic radiation impinges on a material containing a photoactive component to induce a physical or chemical change in that material. An image or latent image which can be processed into a useful image can thereby be produced. Typically actinic radiation useful for imaging is light ranging from the extreme ultraviolet through the visible spectral regions, but may also include infrared, X-ray and electron beam radiation. Although the branched polymer itself may be photoactive, as in some embodiments of this invention, often a photosensitive composition contains one or more photoactive components in addition to the branched polymer. Upon exposure to actinic radiation, the photoactive component acts to change the rheological state, the solubility, the surface characteristics, refractive index, the color, the electromagnetic characteristics or

other such physical or chemical characteristics of the photosensitive composition as described in the aforementioned Thompson et al. publication.

The photosensitive composition of this invention may be applied as a neat, solvent-free, photosensitive liquid or as a solution and dried to a solid layer wherein any conventional coating or printing process may be used. Alternatively, the photosensitive composition may be applied as a dry film in a layer. Alternatively, the layer or film may be applied by laminating a supported solid photosensitive layer to the substrate and then optionally removing the support.

Photoactive Component (PAC)

The compositions of this invention contain at least one photoactive component (PAC) that is a compound which affords acid upon exposure to actinic radiation and which is termed a photoacid generator (PAG). Suitable photoacid generators for this invention include, but are not limited to, 1) sulfonium salts (structure I), 2) iodonium salts (structure II), and 3) hydroxamic acid esters, such as structure III.



In structures I-II, $\text{R}^1\text{-R}^3$ are independently substituted or unsubstituted aryl or substituted or unsubstituted $\text{C}_1\text{-C}_{20}$ alkylaryl (aralkyl). Representative aryl groups include, but are not limited to, phenyl and naphthyl. Suitable substituents include, but are not limited to, hydroxyl (-OH) and $\text{C}_1\text{-C}_{20}$ alkoxy (e.g., $\text{C}_{10}\text{H}_{21}\text{O}$). The anion X^- in structures I-II can be, but is not limited to, SbF_6^- (hexafluoroantimonate), CF_3SO_3^- (trifluoromethylsulfonate = triflate), and $\text{C}_4\text{F}_9\text{SO}_3^-$ (perfluorobutylsulfonate).

Protective Groups for Removal by PAC Catalysis

The branched polymer of this invention may contain one or more components having protected acid groups that can yield, by catalysis of acids or bases generated photolytically from photoactive compounds (PACs), hydrophilic acid groups which enable development of resist coatings. A given protected acid group is one that is normally chosen on the basis of its being acid labile, such that when photoacid is produced upon imagewise exposure, the acid will catalyze deprotection and production of hydrophilic acid groups that are necessary for

development under aqueous conditions. In addition, the graft copolymers may also contain acid functionality that is not protected.

Examples of components having protected acid groups that yield a carboxylic acid as the hydrophilic group upon exposure to photogenerated acid include, but are not limited to, A) esters capable of forming, or rearranging to, a tertiary cation, B) esters of lactone, C) acetal esters, D) β -cyclic ketone esters, E) α -cyclic ether esters, and F) MEEMA (methoxy ethoxy ethyl methacrylate) and other esters which are easily hydrolyzable because of anchimeric assistance. Some specific examples in category A) are t-butyl ester, 2-methyl-2-adamantyl ester, and isobornyl ester. Some specific examples in category B) are γ -butyrolactone-3-yl, γ -butyrolactone-2-yl, mevalonic lactone, 3-methyl- γ -butyrolactone-3-yl, 3-tetrahydrofuran-yl, and 3-oxocyclohexyl. Some specific examples in category C) are 2-tetrahydropyranyl, 2-tetrahydrofuran-yl, and 2,3-propylenecarbonate-1-yl. Additional examples in category C) include various esters from addition of vinyl ethers, such as, for example, ethoxy ethyl vinyl ether, methoxy ethoxy ethyl vinyl ether, and acetoxo ethoxy ethyl vinyl ether. Examples of components having protected acid groups that yield either a phenol or alcohol as the hydrophilic group upon exposure to photogenerated acid or base include, but are not limited to, t-butoxycarbonyl (t-BOC), t-butyl ether, and 3-cyclohexenyl ether.

In this invention, often, but not always, the components having protected groups are repeat units having protected acid groups that have been incorporated in the base copolymer resins of the compositions (as discussed supra). Frequently the protected acid groups are present in one or more comonomer(s) that are polymerized to form a given copolymeric base resin of this invention. Alternatively, in this invention, a copolymeric base resin can be formed by copolymerization with an acid-containing comonomer and then subsequently acid functionality in the resulting acid-containing copolymer can be partially or wholly converted by appropriate means to derivatives having protected acid groups. As one specific example, a graft copolymer of (70) IBA/(30) IBOMA/ tBMA/HEMA 60/20/20 is a copolymeric base resin within the scope of the invention having t-butyl ester groups as protected-acid groups.

It is preferred that one of the segments of the branched polymer contains greater than 50% of the protected acid groups present in the branched polymer. It is more preferred that one of the segments contains at least 75% of the protected acid groups present in the branched polymer. Protected acid groups can be present in either the branch segment(s) (i.e., polymer arms) or in the linear

backbone segment; preferably, protected acid groups are located in the branch polymer segment(s).

Deprotection in this invention entails converting protected acid groups of the branched polymer (that is present in photosensitive compositions) in exposed areas substantially or totally into free acid groups, which thereby impart aqueous developability to the photosensitive composition containing the branched polymer. Generally, a post-exposure bake is required and is utilized to effect deprotection. Typically, following imagewise exposure, a given sample is treated at approximately 25°C to 150°C for approximately 30 seconds to 600 seconds to effect deprotection. While not limiting the invention, the following explanation of deprotection is believed to occur. Imagewise exposure to UV light results in formation of free acid from the PAG in exposed areas. Protected acid groups in exposed areas containing free acid undergo deprotection to afford sufficient free acid groups on the branched polymer, such that is subsequently developable in alkaline developer solution.

Dissolution Inhibitors and Additives

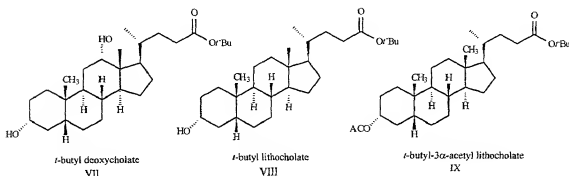
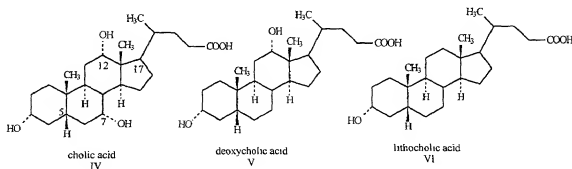
Various dissolution inhibitors can be utilized in this invention. Ideally, dissolution inhibitors (DIs) for far and extreme UV resists (e.g., 193 nm resists) should be designed/chosen to satisfy multiple materials needs including dissolution inhibition, plasma etch resistance, and adhesion behavior of resist compositions comprising a given DI additive. Some dissolution inhibiting compounds also serve as plasticizers in resist compositions.

A variety of bile-salt esters (i.e., cholate esters) are particularly useful as DIs in the compositions of this invention. Bile-salt esters are known to be effective dissolution inhibitors for deep UV resists, beginning with work by Reichmanis et al. in 1983. (E. Reichmanis et al., "The Effect of Substituents on the Photosensitivity of 2-Nitrobenzyl Ester Deep UV Resists", J. Electrochem. Soc. 1983, 130, 1433-1437.) Bile-salt esters are particularly attractive choices as DIs for several reasons, including their availability from natural sources, their possessing a high alicyclic carbon content, and particularly for their being transparent in the deep and vacuum UV region, (which essentially is also the far and extreme UV region), of the electromagnetic spectrum (e.g., typically they are highly transparent at 193 nm). Furthermore, the bile-salt esters are also attractive DI choices since they may be designed to have widely ranging hydrophobic to hydrophilic compatibilities depending upon hydroxyl substitution and functionalization.

Representative bile-acids and bile-acid derivatives that are suitable as additives and/or dissolution inhibitors for this invention include, but are not

limited to, those illustrated below, which are as follows: cholic acid (IV), deoxycholic acid (V), lithocholic acid (VI), t-butyl deoxycholate (VII), t-butyl lithocholate (VIII), and t-butyl-3- α -acetyl lithocholate (IX). Bile-acid esters, including compounds VII-IX, are preferred dissolution inhibitors in this invention.

5



The invention is not limited to use of bile-acid esters and related compounds as dissolution inhibitors. Other types of dissolution inhibitors, such as various diazonaphthoquinones (DNQs) and diazocoumarins (DCs), can be utilized in this invention in some applications. Diazonaphthoquinones and diazocoumarins are generally suitable in resist compositions designed for imaging at higher wavelengths of UV light (e.g., 365 nm and perhaps at 248 nm). These dissolution inhibitors are generally not preferred in resist compositions designed for imaging with UV light at 193 nm or lower wavelengths, since these compounds absorb strongly in this region of the UV and are usually not sufficiently transparent for most applications at these low UV wavelengths.

20 Other Components

The compositions of this invention can contain optional additional components. Examples of additional components which can be added include, but are not limited to, resolution enhancers, adhesion promoters, residue reducers, coating aids, plasticizers, and T_g (glass transition temperature) modifiers.

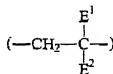
Process Steps

Imagewise Exposure

- The photoresist compositions of this invention are sensitive in the ultraviolet region of the electromagnetic spectrum and especially to those wavelengths ≤ 367 nm. Imagewise exposure of the resist compositions of this invention can be done at many different UV wavelengths including, but not limited to, 365 nm, 248 nm, 193 nm, 157 nm, and lower wavelengths. Imagewise exposure is preferable done with ultraviolet light of 248 nm, 193 nm, 157 nm, or lower wavelengths; is more preferable done with ultraviolet light of 193 nm, 157 nm, or lower wavelengths; and is still more preferably done with ultraviolet light of 157 nm or lower wavelengths. Imagewise exposure can either be done digitally with a laser or equivalent device or non-digitally with use of a photomask. Suitable laser devices for digital imaging of the compositions of this invention include, but are not limited to, an argon-fluorine excimer laser with UV output at 193 nm, a krypton-fluorine excimer laser with UV output at 248 nm, and a fluorine (F2) laser with output at 157 nm. Since, as discussed supra, use of UV light of lower wavelength for imagewise exposure corresponds to higher resolution (lower resolution limit), the use of a lower wavelength (e.g., 193 nm or 157 nm or lower) is generally preferred over use of a higher wavelength (e.g., 248 nm or higher). Specifically, imaging at 157 nm is preferred over imaging at 193 nm for this reason.

Development

- The graft copolymers in the photoresists of this invention must contain sufficient functionality for development following imagewise exposure to UV light. Preferably, the functionality is acid or protected acid such that aqueous development is possible using a basic developer such as sodium hydroxide solution, potassium hydroxide solution, or ammonium hydroxide solution. Some preferred graft copolymers in the resist compositions of this invention are protected acid-containing copolymers comprised of at least one acid-containing monomer of structural unit:



- in which E¹ is H or C₁-C₁₂ alkyl; E² is CO₂, E³ is SO₃E, or other acidic functional group; and E and E³ are H or C₁-C₁₂ alkyl, which is unsubstituted or hydroxyl-substituted. Alkyl groups can contain one to twelve carbon atoms and preferably

one to eight. A preferred acid-containing binder polymer for aqueous processability (aqueous development) in use is a carboxylic acid-containing copolymer. The level of carboxylic acid groups is determined for a given composition by optimizing the amount needed for good development in aqueous alkaline developer.

When an aqueous processable photoresist is coated or otherwise applied to a substrate and imagewise exposed to UV light, development of the photoresist composition may require that the binder material should contain sufficient acid groups (e.g., carboxylic acid groups) and/or protected acid groups that are at least partially deprotected upon exposure to render the photoresist (or other photoimageable coating composition) processable in aqueous alkaline developer. In case of a positive-working photoresist layer, the photoresist layer will be removed during development in portions which are exposed to UV radiation but will be substantially unaffected in unexposed portions during development by aqueous alkaline liquids such as aqueous solutions containing 0.262 N tetramethylammonium hydroxide (with development at 25°C usually for less than or equal to 120 seconds) or 1% sodium carbonate by weight (with development at a temperature of 30°C usually for less than or equal to 2 minutes).

GLOSSARY

Chemicals/Monomers

AA	Acrylic acid
1-AdA	Aldrich Chemical Co., Milwaukee, WI
AIBN	1-Adamantyl acrylate
	2,2'-azobisisobutyronitrile
AMS	Aldrich Chemical Co., Milwaukee, WI
	alpha-Methyl styrene
AMSD	Aldrich Chemical Co., Milwaukee, WI
	alpha-Methyl styrene dimer
	Goi Chemicals Ltd., Houston, TX
BuAc	n-Butyl acetate
	Aldrich Chemical Co., Milwaukee, WI
DMG Co(III)	Isopropyl-bis(borondimethylglyoximate)cobaltate (III)
Catalyst	E. I. du Pont de Nemours, Sydney, Australia
HEMA	2-Hydroxyethyl methacrylate
	Aldrich Chemical Co., Milwaukee, WI
HMDS	Hexamethyldisilazane
	Aldrich Chemical Co., Milwaukee, WI

	IBA	Isobornyl acrylate Aldrich Chemical Co., Milwaukee, WI
	IBOMA	Isobornyl methacrylate Aldrich Chemical Co., Milwaukee, WI
5	ITA	Itaconic anhydride Aldrich Chemical Co., Milwaukee, WI
	MAA	Methacrylic acid Aldrich Chemical Co., Milwaukee, WI
	MEK	2-Butanone Aldrich Chemical Co., Milwaukee, WI
10	MIBK	Methyl isobutyl ketone Aldrich Chemical Co., Milwaukee, WI
	PGMEA	Propylene glycol methyl ether acetate Aldrich Chemical Co., Milwaukee, WI
15	STY	Styrene Aldrich Chemical Co., Milwaukee, WI
	tBA	tertiary-Butyl acrylate
	tBMA	tertiary-Butyl methacrylate TCI America, Portland, OR
20	tBPP	tertiary-Butyl perpivalate Elf Atochem, Philadelphia, PA
	TMAH	Tetramethylammonium hydroxide Onka NMD-3, 0.238N aqueous solution unless otherwise noted)
25	Vazo®52 Initiator	Aldrich Chemical Co., Milwaukee, WI 2,2'-Azobis(2,4-dimethylpentane nitrile) CAS No. 4419-11-8 (E. I. du Pont de Nemours, Wilmington, DE)
30	Vazo®67 Initiator	2,2'-Azobis(2-methylbutanenitrile) CAS No. 13472-08-7 (E. I. du Pont de Nemours, Wilmington, DE)
	Vazo®88 Initiator	1,1'-Azobis(Cyclohexanecarbonitrile) CAS No. 2094-98-6 (E. I. du Pont de Nemours, Wilmington, DE)
35	Zonyl®88	C ₄ -C ₁₀ Perfluoro-n-alkyl methacrylate (E. I. du Pont de Nemours, Wilmington, DE)
	Zonyl®TAN	C ₄ -C ₁₀ Perfluoro-n-alkyl acrylate (E. I. du Pont de Nemours, Wilmington, DE)

General

	DRM	Dissolution rate monitor – instrument that is designed to accurately measure the rate at which resist is removed during development. This rate is termed the dissolution rate
5	Gm	Gram(s)
	Min	Minute(s)
	PAG	Photoacid Generator
	Sec	Second(s)
10	M_n	Number-average molecular weight of a given polymer
	M_w	Weight-average molecular weight of a given polymer
	$P = M_w/M_n$	Polydispersity (dispersity) of a given polymer
15	UV	Ultraviolet (UV) Ultraviolet region of the electromagnetic spectrum which ranges from 10 nanometers to 390 nanometers
20	Extreme UV	Region of the electromagnetic spectrum in the ultraviolet that ranges from 10 nanometers to 200 nanometers
	Far UV	Region of the electromagnetic spectrum in the ultraviolet that ranges from 200 nanometers to 300 nanometers
25	Near UV	Region of the electromagnetic spectrum in the ultraviolet that ranges from 300 nanometers to 390 nanometers

Polymers

	(70) IBA/(30) IBOMA/tBMA/HEMA	
30	60/20/20 Graft Copolymer	Graft copolymer that is 70% backbone of IBA and 30% sidearms of IBOMA/tBMA/HEMA in amounts of 60%, 20%, and 20%, respectively
35	IBA/IBMOMA/tBMA/HEMA	
	70/18/6/6	Random copolymer containing IBA,
	Random Copolymer	IBOMA, tBMA, HEMA in amounts of 70%, 18%, 6%, and 6%, respectively
	(70)IBOMA/(30)IBOMA/tBMA/HEMA	

5	60/20/20 Block Copolymer	A/B block copolymer having an A block of repeat units derived from IBOMA and a B block of repeat units of IBOMA, tBMA, and HEMA in amounts of 60%, 20%, and 20%, respectively. Polymer contains 70% A block and 30% B block.
10	(70)IBA/(30)IBOMA/tBMA/HEMA 39/41/20 Graft Copolymer	Graft copolymer that is 70% backbone of IBA and 30% sidearms of IBOMA/tBMA/HEMA in amounts of 39%, 41%, and 20%, respectively
15	IBA/IBOMA/tBMA/HEMA 70/12/12/6 Random Copolymer	Random copolymer containing IBA, IBOMA, tBMA, HEMA in amounts of 70%, 12%, 12%, and 6%, respectively
20	(70)IBA/(30)IBOMA/MEEMA 46/54 Graft Copolymer	Graft copolymer that is 70% backbone of IBA and 30% sidearms of IBOMA, and MEEMA in amounts of 46% and 54%, respectively.
25	(70)IBA/(30)IBOMA/tBMA/ITA 51/41/8 Graft Copolymer	Graft copolymer that is 70% backbone of IBA and 30% sidearms of IBOMA, tBMA, and ITA in amounts of 51%, 41%, and 8%, respectively
30	IBA/IBOMA/tBMA/ITA 70/15.3/ 12.3/2.4Random Copolymer	Random copolymer containing IBA, IBOMA, tBMA, ITA in amounts of 70%, 15.3%, 12.3%, and 2.4%, respectively.
35	(70)IBA/(30)IBOMA/tBMA/ITA/AMS 47/38.5/7.5/7 Graft Copolymer	Graft copolymer that is 70% backbone of IBA and 30% sidearms of IBOMA, tBMA, ITA, and AMS in amounts of 47%, 38.5%, 7.5%, and 7%, respectively
	(70)ZONYL® TAN/(30)IBOMA/tBMA/	

	ITA 56/41/3 Graft Copolymer	Graft copolymer that is 70% backbone of C ₄ -C ₁₀ perfluoro-n-alkyl acrylate and 30% sidearms of IBOMA, tBMA, and ITA in amounts of 56%, 41%, and 3%, respectively
5	ZONYL® TAN/IBOMA/tBMA/ ITA 70/16.8/12.3/1 Random Copolymer	Random copolymer containing C ₄ -C ₁₀ perfluoro-n-alkyl acrylate, IBOMA, tBMA, and ITA in amounts of 70%, 16.8%, 12.3% and 1%, respectively
10	(70)IBA/STY 75/25/(30)IBOMA/tBMA/ ITA 51/41/8 Graft Copolymer	Graft copolymer that is 70% backbone of IBA (75%) and STY (25%) and 30% sidearms of IBOMA, tBMA, and ITA in amounts of 51%, 41%, and 8%, respectively
15	IBA/STY/IBOMA/tBMA/ITA 52.5/ 17.5/15.3/12.3/2.4 Random Copolymer	Random copolymer containing IBA, STY, IBOMA, tBMA, and ITA in amounts of 52.5%, 17.5%, 15.3%, 12.3%, and 2.4%, respectively.
20	IBA/tBMA/HEMA 85.4/7.3/7.3 Random Copolymer	Random copolymer containing IBA, tBMA, and HEMA in amounts of 85.4%, 7.3%, and 7.3%, respectively
25	IBOMA/tBMA/HEMA 60/20/20 Random Copolymer	Random copolymer containing IBOMA, tBMA, and HEMA in amounts of 60%, 20%, and 20%, respectively
30	IBA/IBOMA/HEMA 74.5/19.1/6.4 Random Copolymer	Random copolymer containing IBA, IBOMA, and HEMA in amounts of 74.5%, 19.1%, and 6.4%, respectively
35	IBA/IBOMA/tBMA 76/18/6 Random Copolymer	Random copolymer of IBA, IBOMA,

and tBMA in amounts of 76%, 18%,
and 6%, respectively

IBA Homopolymer

Homopolymer of IBA

EXAMPLES

- 5 Unless otherwise specified, all temperatures are in degrees Centigrade (°C), all mass measurements are in grams, and all percentages are weight percentages.

EXAMPLE 1

IBOMA/tBMA/HEMA 60/20/20 Macromonomer

- 10 The macromonomer was prepared by charging the following components to a 1 liter flask equipped with a thermocouple, stirrer, dropping funnels, reflux condenser, and the means for bubbling nitrogen through the reaction.

	Parts by Weight	Grams
Portion 1		
t-butyl methacrylate (tBMA)		25.98
Isobornyl methacrylate (IBOMA)		77.94
2-Hydroxyethyl methacrylate (HEMA)		25.98
Methyl ethyl ketone (MEK)		168.74
Portion 2		
Methylethyl ketone (MEK)		17.41
Isopropyl-bis(borondifluorodimethylglyoximate) cobaltate (III) Catalyst (DMG Co(III))		0.004
VAZO® 52 Initiator		0.13
Portion 3		
Methyl ethyl ketone (MEK)		10.13
Portion 4		
DMG Co (III) Catalyst		0.004
VAZO® 52 Initiator		1.43
Methylethyl ketone		52.09
Portion 5		
t-butyl methacrylate (tBMA)		24.03
Isobornyl methacrylate (IBOMA)		72.10
2-Hydroxyethyl methacrylate (HEMA)		24.03
Total		500.00

- 15 Portion 1 was heated to its reflux temperature in about 15 minutes.
Portion 2 was thoroughly mixed and added as shot and the composition was held at its reflux temperature for 5 minutes. The vessel which contained Portion 2 was

- rinsed with Portion 3, which was then added to the reaction vessel along with Portion 2. Portions 4 and 5 were mixed and then added simultaneously to the reaction vessel while the vessel maintained its reflux temperature. For Portion 4, the first 54.8% was added over 90 minutes, and the remaining 45.2% was added over 240 minutes. For Portion 5, the first 67% was added over 120 minutes, and the remaining 33% was added over an additional 120 minutes. After Portions 4 and 5 were added to the vessel, the reaction was held at reflux for an additional 45 minutes. After the 45 minute hold, the reaction was cooled to room temperature.
- The resulting macromonomer solution had a solids content of 50.3%, a M_n of 5400 and a polydispersity of 2.02.

EXAMPLE 2

(70) IBA/(30) IBOMA/tBMA/HEMA 60/20/20 Graft Copolymer

- The macromonomer prepared in Example 1 was used in the following graft copolymer synthesis.

The following components were charged into a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
Macromonomer (Example 1)		181.57
Isobornyl acrylate (IBA)		39.03
MEK		54.76
Portion 2		
t-butyl peroxyvalate		2.37
MEK		12.50
Portion 3		
IBA		174.24
Portion 4		
t-butyl peroxyvalate		2.37
MEK		23.69
Portion 5		
t-butyl peroxyvalate		4.74
MEK		4.74
Total		500.00

- Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. Portion 2 was mixed and charged to the reactor in two equal portions - after the first was added, the reaction was held at reflux for 10 minutes before the

- second half was added. After the second half of Portion 2 was added, the reaction was held at reflux for 10 minutes. After the hold, Portions 3 and 4 were each added simultaneously to the reaction vessel while maintaining its contents at reflux. Portion 3 was added over 180 minutes, and Portion 4 was added over 240 minutes. After the additions of Portions 3 and 4 were completed, Portion 5 was thoroughly mixed and added to the reaction vessel over 15 minutes, maintaining the reflux temperature. After the addition of Portion 5 was completed, the reaction mixture was maintained at reflux for 120 minutes and then cooled to room temperature.
- The resulting graft copolymer solution had a solids content of 68.64%, a M_n of 8600 and a dispersity of 3.40.

EXAMPLE 3

IBA/tBOMA/tBMA/HEMA 70/18/6/6 Random Copolymer

- The following components were charged in a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
IBOMA		9.89
tBMA		3.30
IBA		38.46
HEMA		3.30
MEK		82.42
Portion 2		
IBA		153.85
IBOMA		39.56
tBMA		13.19
HEMA		13.19
Portion 3		
Vazo®52 Initiator		5.49
MEK		137.36
Total		500.00

- Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. At reflux 10% of portion 3 was added to the reaction flask. After a 5 minute hold the remainder of portion 3 was added over 270 minutes while part 2 was being added over 240 minutes. At the end of both feeds the reaction mixture was held at reflux for an additional 30 minutes. The resulting random copolymer solution had a solids content of 59.82%, a M_n of 7700 and a dispersity of 2.60.

EXAMPLE 4(70)IBOMA/(30)IBOMA/tBMA/HEMA 60/20/20 Block Copolymer

The following components were charged to a 1 liter flask equipped as in Example 1.

5

	Parts by Weight	Grams
Portion 1		
n-Butyl acetate		141.31
Macromonomer (Example 1)		140.35
Portion 2		
IBOMA		179.33
Vazo®67 Initiator		0.85
n-Butyl acetate		35.33
Portion 3		
Vazo®67 Initiator		1.41
n-Butyl acetate		70.66
Total		500.00

Portion 1 was heated up to reflux and 69.24 gm. of MEK from the macromonomer was distilled out. When all the MEK was distilled out and the reflux temperature was 95°C, portion 2 was added over 4 hours. When the addition of portion 2 was finished, portion 3 was added over 1 hour and then the reaction mixture was maintained at reflux for an additional 1 hour. The resulting block copolymer solution had a solid content of 52.8%, a M_n of 15,000 and a dispersity of 2.01.

10

EXAMPLE 5IBOMA/tBMA/HEMA 39/41/20 Macromonomer

15

The macromonomer was prepared by charging the following components to a 1 liter flask equipped with a thermocouple, stirrer, dropping funnels, reflux condenser, and the means for bubbling nitrogen through the reaction.

	Parts by Weight	Grams
Portion 1		
t-butyl methacrylate (tBMA)		53.58
Isobornyl methacrylate (IBOMA)		50.34
2-Hydroxyethyl methacrylate (HEMA)		25.98
Methyl ethyl ketone (MEK)		168.74

Parts by Weight	Grams
Portion 2	
Methylethyl ketone (MEK)	17.41
Isopropyl-bis(borondifluorodimethylglyoximate)cobaltate (III) Catalyst (DMG Co(III))	0.004
VAZO®52 Initiator	0.13
Portion 3	
Methyl ethyl ketone (MEK)	10.13
Portion 4	
DMG Co (III) Catalyst	0.004
VAZO®52 Initiator	1.43
Methylethyl ketone	52.09
Portion 5	
t-butyl methacrylate (tBMA)	49.56
Isobornyl methacrylate (IBOMA)	46.56
2-Hydroxyethyl methacrylate (HEMA)	24.03
Total	500.00

Portion 1 was heated to its reflux temperature in about 15 minutes. Portion 2 was thoroughly mixed and added as shot and the composition was held at its reflux temperature for 5 minutes. The vessel which contained Portion 2 was rinsed with Portion 3, which was then added to the reaction vessel along with Portion 2. Portions 4 and 5 were mixed and then added simultaneously to the reaction vessel while the vessel maintained its reflux temperature. For Portion 4, the first 54.8% was added over 90 minutes, and the remaining 45.2% was added over 240 minutes. For Portion 5, the first 67% was added over 120 minutes, and the remaining 33% was added over an additional 120 minutes. After Portions 4 and 5 were added to the vessel, the reaction was held at reflux for an additional 45 minutes. After the 45 minute hold, the reaction was cooled to room temperature.

The resulting macromonomer solution had a solids content of 50.0%, a M_n of 9000 and a polydispersity of 2.05.

EXAMPLE 6

(70)IBA/(30)IBOMA/tBMA/HEMA 39/41/20 Graft Copolymer

The macromonomer prepared in Example 5 was used in the following graft co-polymer synthesis. The following components were charged into a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
Macromonomer (Example 5)		181.57
Isobornyl acrylate (IBA)		39.03
MEK		54.76
Portion 2		
t-butyl peroxyvalate		2.37
MEK		12.50
Portion 3		
IBA		174.24
Portion 4		
t-butyl peroxyvalate		2.37
MEK		23.69
Portion 5		
t-butyl peroxyvalate		4.74
MEK		4.74
Total		500.00

Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. Portion 2 was mixed and charged to the reactor in two equal portions - after the first was added, the reaction was held at reflux for 10 minutes before the second half was added. After the second half of Portion 2 was added, the reaction was held at reflux for 10 minutes. After the hold, Portions 3 and 4 were each added simultaneously to the reaction vessel while maintaining its contents at reflux. Portion 3 was added over 180 minutes, and Portion 4 was added over 240 minutes. After the additions of Portions 3 and 4 were completed, Portion 5 was thoroughly mixed and added to the reaction vessel over 15 minutes, maintaining the reflux temperature. After the addition of Portion 5 was completed, the reaction mixture was maintained at reflux for 120 minutes and then cooled to room temperature. The resulting graft copolymer solution had a solids content of 64.78%, a M_w of 22,400 and a dispersity of 3.44.

EXAMPLE 7

IBA/tBOMA/tBMA/HEMA 70/12/12/6 Random Copolymer

The following components were charged in a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
IBOMA		6.60
tBMA		6.60
IBA		38.46
HEMA		3.30
MEK		82.42
Portion 2		
IBA		153.85
IBOMA		23.97
tBMA		23.97
HEMA		13.19
Portion 3		
Vazo®52 Initiator		5.49
MEK		137.36
Total		500.00

- Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. At reflux 10% of portion 3 was added to the reaction flask. After a 5 minute hold the remainder of portion 3 was added over 270 minutes while part 2 was being added over 240 minutes. At the end of both feeds the reaction mixture was held at reflux for an additional 30 minutes. The resulting random copolymer solution had a solids content of 55.6%, a M_n of 9800 and a dispersity of 2.65.

EXAMPLE 8

IBOMA/MEEMA 46/54 Macromonomer

- The macromonomer was prepared by charging the following components to a 1 liter flask equipped with a thermocouple, stirrer, dropping funnels, reflux condenser, and the means for bubbling nitrogen through the reaction.

	Parts by Weight	Grams
Portion 1		
Methoxyethoxyethyl methacrylate (MEEMA)		70.17
Isobornyl methacrylate (IBOMA)		59.77
Methyl ethyl ketone (MEK)		168.79
Portion 2		
Methylethyl ketone (MEK)		17.41
Isopropyl-bis(borondifluorodimethylgloximate) cobalate (III)		0.004
Catalyst (DMG Co(III))		
VAZO®52 Initiator		0.13

	Parts by Weight	Grams
Portion 3		
	Methyl ethyl ketone (MEK)	10.13
Portion 4		
	DMG Co (III) Catalyst	0.004
	VAZO®52 Initiator	1.43
	Methylethyl ketone	52.09
Portion 5		
	MEEMA	67.24
	Isobornyl methacrylate (IBOMA)	52.82
Total		500.00

Portion 1 was heated to its reflux temperature in about 15 minutes.

Portion 2 was thoroughly mixed and added as shot and the composition was held at its reflux temperature for 5 minutes. The vessel which contained Portion 2 was rinsed with Portion 3, which was then added to the reaction vessel along with Portion 2. Portions 4 and 5 were mixed and then added simultaneously to the reaction vessel while the vessel maintained its reflux temperature. For Portion 4, the first 54.8% was added over 90 minutes, and the remaining 45.2% was added over 240 minutes. For Portion 5, the first 67% was added over 120 minutes, and the remaining 33% was added over an additional 120 minutes. After Portions 4 and 5 were added to the vessel, the reaction was held at reflux for an additional 45 minutes. After the 45 minute hold, the reaction was cooled to room temperature.

The resulting macromonomer solution had a solids content of 50.3%, a M_n of 2000 and a polydispersity of 1.77.

EXAMPLE 9

(70)IBA/(30)IBOMA/MEEMA 46/54 Graft Copolymer

The macromonomer prepared in Example 8 was used in the following graft copolymer synthesis. The following components were charged into a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
	Macromonomer (Example 8)	189.81
	Isobornyl acrylate (IBA)	38.02
	MEK	53.34

	Parts by Weight	Grams
Portion 2		
t-butyl peroxyphthalate		2.31
MEK		12.17
Portion 3		
IBA		169.73
Portion 4		
t-butyl peroxyphthalate		2.31
MEK		23.08
Portion 5		
t-butyl peroxyphthalate		4.61
MEK		4.61
Total		500.00

Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. Portion 2 was mixed and charged to the reactor in two equal portions - after the first was added, the reaction was held at reflux for 10 minutes before the second half was added. After the second half of Portion 2 was added, the reaction was held at reflux for 10 minutes. After the hold, Portions 3 and 4 were each added simultaneously to the reaction vessel while maintaining its contents at reflux. Portion 3 was added over 180 minutes, and Portion 4 was added over 240 minutes. After the additions of Portions 3 and 4 were completed, Portion 5 was thoroughly mixed and added to the reaction vessel over 15 minutes, maintaining the reflux temperature. After the addition of Portion 5 was completed, the reaction mixture was maintained at reflux for 120 minutes and then cooled to room temperature. The resulting graft copolymer solution had a solids content of 64.93%, a M_w of 18,700 and a dispersity of 3.16.

EXAMPLE 10

IBOMA/tBMA/ITA 51/41/8 Macromonomer

The macromonomer was prepared by charging the following components to a 1 liter flask equipped with a thermocouple, stirrer, dropping funnels, reflux condenser, and the means for bubbling nitrogen through the reaction.

	Parts by Weight	Grams
Portion 1		
t-butyl methacrylate (tBMA)		51.73
Isobornyl methacrylate (IBOMA)		63.54
Itaconic anhydride (ITA)		9.87
Methyl ethyl ketone (MEK)		100.19

	Parts by Weight	Grams
Portion 2		
	Methylethyl ketone (MEK)	16.80
	Isopropyl-bis(borondifluorodimethylglyoximate)cobaltate (III)	0.004
	Catalyst (DMG Co(III))	
	VAZO®52 Initiator	0.13
Portion 3		
	Methyl ethyl ketone (MEK)	9.78
Portion 4		
	DMG Co (III) Catalyst	0.004
	VAZO®52 Initiator	1.38
	Methylethyl ketone	52.28
Portion 5		
	t-butyl methacrylate (tBMA)	47.84
	Isobornyl methacrylate (IBOMA)	58.89
	Itaconic anhydride (ITA)	9.43
	MEK	80.13
	Total	500.00

Portion 1 was heated to its reflux temperature in about 15 minutes.

- Portion 2 was thoroughly mixed and added as shot and the composition was held at its reflux temperature for 5 minutes. The vessel which contained Portion 2 was
- 5 rinsed with Portion 3, which was then added to the reaction vessel along with Portion 2. Portions 4 and 5 were mixed and then added simultaneously to the reaction vessel while the vessel maintained its reflux temperature. For Portion 4, the first 54.8% was added over 90 minutes, and the remaining 45.2% was added over 240 minutes. For Portion 5, the first 67% was added over 120 minutes, and
- 10 the remaining 33% was added over an additional 120 minutes. After Portions 4 and 5 were added to the vessel, the reaction was held at reflux for an additional 45 minutes. After the 45 minute hold, the reaction was cooled to room temperature.

- The resulting macromonomer solution had a solids content of 44.69%, a
- 15 M_n of 9400 and a polydispersity of 2.14.

EXAMPLE 11(70)IBA/(30)IBOMA/IBMA/ITA 51/41/8 Graft Copolymer

The macromonomer prepared in Example 10 was used in the following graft co-polymer synthesis. The following components were charged into a 1 liter flask equipped as in Example 1.

Parts by Weight	Grams
Portion 1	
Macromonomer (Example 10)	185.73
Isobornyl acrylate (IBA)	38.52
MEK	54.04
Portion 2	
t-butyl peroxyphthalate	2.34
MEK	12.33
Portion 3	
IBA	171.97
Portion 4	
t-butyl peroxyphthalate	2.34
MEK	23.38
Portion 5	
t-butyl peroxyphthalate	4.67
MEK	4.67
Total	500.00

Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. Portion 2 was mixed and charged to the reactor in two equal portions - after the first was added, the reaction was held at reflux for 10 minutes before the second half was added. After the second half of Portion 2 was added, the reaction was held at reflux for 10 minutes. After the hold, Portions 3 and 4 were each added simultaneously to the reaction vessel while maintaining its contents at reflux. Portion 3 was added over 180 minutes, and Portion 4 was added over 240 minutes. After the additions of Portions 3 and 4 were completed, Portion 5 was thoroughly mixed and added to the reaction vessel over 15 minutes, maintaining the reflux temperature. After the addition of Portion 5 was completed, the reaction mixture was maintained at reflux for 120 minutes and then cooled to room temperature. The resulting graft copolymer solution had a solids content of 62.66%, a M_w of 20,000 and a dispersity of 3.10.

EXAMPLE 12(70)IBA/(30)IBOMA/tBMA/ITA 51/41/8 Graft Copolymer in PGMEA

- 5 500 gm of graft copolymer prepared as in Example 11 was placed in a 1 liter flask equipped with a mechanical stirrer, a thermocouple, nitrogen bleed and a distillation column. 307 gm. of propylene glycol methyl ether acetate (PGMEA) were added to the flask and 193.6 gm of methyl ethyl ketone were distilled out. The resulting solution had a solids content of 57.21% solids.

EXAMPLE 13IBA/IBOMA/tBMA/ITA 70/15.3/12.3/2.4 Random Copolymer

- 10 The following components were charged in a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
IBOMA		7.57
tBMA		6.09
IBA		34.65
ITA		1.19
MEK		74.26
Portion 2		
IBA		138.61
IBOMA		30.30
tBMA		24.36
ITA		4.75
MEK		74.26
Portion 3		
Vazo®52 Initiator		4.95
MEK		99.01
Total		500.00

- 15 Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. At reflux 10% of portion 3 was added to the reaction flask. After a 5 minute hold the remainder of portion 3 was added over 270 minutes while part 2 was being added over 240 minutes. At the end of both feeds the reaction mixture was held at reflux for an additional 30 minutes. After the hold 247.5 gm of PGMEA were added to the flask and 255.5 gm of solvent was distilled out of the
- 20 reaction mixture. The resulting random copolymer solution had a solids content of 58.29%, a M_w of 14,900 and a dispersity of 2.37.

EXAMPLE 14IBOMA/tBMA/ITA/AMS 47/38.5/7.5/7 Macromonomer

The following components were charged in a 1 liter flask equipped as in Example 1.

5

	Parts by Weight	Grams
Portion 1		
alpha methyl styrene dimer (AMSD)		14.31
PGMEA		82.47
Portion 2		
tBMA		78.51
ITA		15.23
IBOMA		96.60
PGMEA		82.47
Portion 3		
Vazo®88		4.54
PGMEA		125.89
Total		500.00

Portion 1 was heated to reflux (130°C) over 30 minutes. After 20 minutes of heating, 10% of part 2 and 2% of part 3 were added to the flask. When the contents of the flask reached 130°C, the remainder of portions 2 and 3 were fed in the following manner; 30% of each over 1 hour, the next 40% over 150 minutes, and the remainder over an additional 150 minutes. After the feeds were all in, the reaction mixture was held at reflux for an additional 1 hour. The resulting macromonomer solution had a solids content of 34.36%, a M_n of 2300 with a dispersity of 1.67.

10

EXAMPLE 15(70)IBA/((30)IBOMA/tBMA/ITA/AMS 47/38.5/7.5/7 Graft Copolymer

The macromonomer prepared in Example 14 was used in the following graft co-polymer synthesis. The following components were charged into a 1 liter flask equipped as in Example 1.

15

	Parts by Weight	Grams
Portion 1		
Macromonomer (Example 14)		203.43
Isobornyl acrylate (IBA)		36.35
MEK		51.00
Portion 2		
t-butyl peroxyphthalate		2.21
MEK		11.64
Portion 3		
IBA		162.28
Portion 4		
t-butyl peroxyphthalate		2.21
MEK		22.06
Portion 5		
t-butyl peroxyphthalate		4.41
MEK		4.41
Total		500.00

Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. Portion 2 was mixed and charged to the reactor in two equal portions - after the first was added, the reaction was held at reflux for 10 minutes before the second half was added. After the second half of Portion 2 was added, the reaction was held at reflux for 10 minutes. After the hold, Portions 3 and 4 were each added simultaneously to the reaction vessel while maintaining its contents at reflux. Portion 3 was added over 180 minutes, and Portion 4 was added over 240 minutes. After the additions of Portions 3 and 4 were completed, Portion 5 was thoroughly mixed and added to the reaction vessel over 15 minutes, maintaining the reflux temperature. After the addition of Portion 5 was completed, the reaction mixture was maintained at reflux for 120 minutes and then cooled to room temperature. The resulting graft copolymer solution had a solids content of 62.50%, a M_w of 10,200 and a dispersity of 2.25.

15

EXAMPLE 16IBOMA/tBMA/ITA 56/41/3 Macromonomer

The macromonomer was prepared by charging the following components to a 1 liter flask equipped with a thermocouple, stirrer, dropping funnels, reflux condenser, and the means for bubbling nitrogen through the reaction.

20

	Parts by Weight	Grams
Portion 1		
t-butyl methacrylate (tBMA)		51.72
Isobornyl methacrylate (IBOMA)		69.81
Itaconic anhydride (ITA)		3.70
Methyl ethyl ketone (MEK)		100.19
Portion 2		
Methylethyl ketone(MEK)		16.80
Isopropyl-bis(borondifluorodimethylglyoximate) cobaltate (III) Catalyst (DMG Co(III))		0.004
VAZO®52 Initiator		0.13
Portion 3		
Methyl ethyl ketone (MEK)		9.78
Portion 4		
DMG Co (III) Catalyst		0.004
VAZO®52 Initiator		1.38
Methylethyl ketone		52.28
Portion 5		
t-butyl methacrylate (tBMA)		47.84
Isobornyl methacrylate (IBOMA)		64.69
Itaconic anhydride (ITA)		3.54
MEK		80.13
Total		500.00

Portion 1 was heated to its reflux temperature in about 15 minutes.

Portion 2 was thoroughly mixed and added as shot and the composition was held at its reflux temperature for 5 minutes. The vessel which contained Portion 2 was
 5 rinsed with Portion 3, which was then added to the reaction vessel along with Portion 2. Portions 4 and 5 were mixed and then added simultaneously to the reaction vessel while the vessel maintained its reflux temperature. For Portion 4, the first 54.8% was added over 90 minutes, and the remaining 45.2% was added over 240 minutes. For Portion 5, the first 67% was added over 120 minutes, and
 10 the remaining 33% was added over an additional 120 minutes. After Portions 4 and 5 were added to the vessel, the reaction was held at reflux for an additional 45 minutes. After the 45 minute hold, the reaction was cooled to room temperature.

The resulting macromonomer solution had a solids content of 46.78%, a
 15 M_n of 10,800 and a polydispersity of 1.93.

EXAMPLE 17(70)ZONYL® TAN/(30)IBOMA/tBMA/TA 56/41/3 Graft Copolymer

The macromonomer prepared in Example 16 was used in the following graft copolymer synthesis. The following components were charged into a 1 liter
 5 flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
Macromonomer (Example 16)		146.18
Perfluoroalkyl acrylate (ZONYL® TAN)		30.32
Methyl isobutyl ketone (MIBK)		42.53
Portion 2		
t-butyl peroxyvalerate		0.14
Vazo®88		1.84
MIBK		9.71
Portion 3		
ZONYL® TAN		135.35
MIBK		106.33
Portion 4		
Vazo®88		1.84
MIBK		18.40
Portion 5		
Vazo®88		3.68
MIBK		8.97
Total		500.00

Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. Portion 2 was mixed and charged to the reactor in two equal portions
 10 - after the first was added, the reaction was held at reflux for 10 minutes before the second half was added. After the second half of Portion 2 was added, the reaction was held at reflux for 10 minutes. After the hold, Portions 3 and 4 were each added simultaneously to the reaction vessel while maintaining its contents at reflux. Portion 3 was added over 180 minutes, and Portion 4 was added over
 15 240 minutes. After the additions of Portions 3 and 4 were completed, Portion 5 was thoroughly mixed and added to the reaction vessel over 15 minutes, maintaining the reflux temperature. After the addition of Portion 5 was completed, the reaction mixture was maintained at reflux for 120 minutes and then cooled to room temperature. The resulting graft copolymer solution had a solids
 20 content of 48.73%, a M_w of 24,800 and a dispersity of 1.71.

EXAMPLE 18ZONYL® TAN/IBOMA/tBMA/ITA 70/16.8/12.3/1 Random Copolymer

The following components were charged in a 1 liter flask equipped as in Example 1.

5

	Parts by Weight	Grams
Portion 1		
IBOMA		7.09
tBMA		5.19
ZONYL® TAN		29.49
ITA		0.42
MIBK		63.29
Portion 2		
ZONYL® TAN		117.97
IBOMA		28.35
tBMA		20.76
ITA		1.69
MIBK		158.23
Portion 3		
Vazo®88 Initiator		4.22
MIBK		63.29
Portion 4		
Vazo®88 Initiator		1.0
MIBK		8.0
Total		509.00

Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. At reflux 10% of portion 3 was added to the reaction flask. After a 5 minute hold the remainder of portion 3 was added over 270 minutes while part 2 was being added over 240 minutes. At the end of feed 3, feed 4 was added over 30 minutes and then the reaction mixture was held at reflux for an additional 30 minutes. The resulting random copolymer solution had a solids content of 40.69%, a M_w of 18,000 and a dispersity of 1.57.

10

EXAMPLE 19(70)IBA/STY 75/25/(30)IBOMA/tBMA/ITA 51/41/8 Graft Copolymer

The macromonomer prepared in Example 10 was used in the following graft copolymer synthesis. The following components were charged into a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
Macromonomer (Example 10)		185.74
Isobornyl acrylate (IBA)		28.89
Styrene (STY)		9.63
MEK		54.04
Portion 2		
t-butyl peroxyvalerate		2.00
MEK		12.33
Portion 3		
IBA		128.97
STY		42.99
Portion 4		
t-butyl peroxyvalerate		2.00
MEK		23.38
Portion 5		
t-butyl peroxyvalerate		4.00
MEK		4.67
Total		500.00

Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. Portion 2 was mixed and charged to the reactor in two equal portions - after the first was added, the reaction was held at reflux for 10 minutes before the second half was added. After the second half of Portion 2 was added, the reaction was held at reflux for 10 minutes. After the hold, Portions 3 and 4 were each added simultaneously to the reaction vessel while maintaining its contents at reflux. Portion 3 was added over 180 minutes, and Portion 4 was added over 240 minutes. After the additions of Portions 3 and 4 were completed, Portion 5 was thoroughly mixed and added to the reaction vessel over 15 minutes, maintaining the reflux temperature. After the addition of Portion 5 was completed, the reaction mixture was maintained at reflux for 120 minutes and then cooled to room temperature. The resulting graft copolymer solution had a solids content of 60.07%, a M_w of 31,500 and a dispersity of 2.80.

EXAMPLE 20

IBA/STY/tBOMA/tBMA/ITA 52.5/17.5/15.3/12.3/2.4 Random Copolymer

The following components were charged in a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
IBOMA		7.57
tBMA		6.09
IBA		25.99
STY		8.66
ITA		1.19
MEK		74.26
Portion 2		
IBA		103.96
STY		34.65
IBOMA		30.30
tBMA		24.36
ITA		4.75
MEK		74.26
Portion 3		
Vazo®52 Initiator		4.95
MEK		99.01
Total		500.00

Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. At reflux 10% of portion 3 was added to the reaction flask. After a 5 minute hold the remainder of portion 3 was added over 270 minutes while part 2 was being added over 240 minutes. At the end of both feeds the reaction mixture was held at reflux for an additional 30 minutes. After the hold 247.5 grams of PGMEA were added to the flask and 255.5 grams of solvent was distilled out of the reaction mixture. The resulting random copolymer solution had a solids content of 57.21%, a M_w of 12,300 and a dispersity of 2.34.

EXAMPLE 21

A photoresist composition was made at 29.6% solids as summarized below:

Component	Wt. (gm)
Graft Copolymer Solution (Example 11)	9.8
(70) IBA/(30) IBOMA/tBMA/ITA 51/41/8	
that was additionally dried to 86.2% solids by rotary evaporation	
Propylene glycol methyl ether acetate (PGMEA)	20.2

Component	Wt. (gm)
Diaryl iodonium hexafluoroantimonate salt:	0.6
4-(2-hydroxyl-1-tetradecyloxyphenyl) phenyl iodonium hexafluoroantimonate [Sartomer SarCar™ CD-1012 solid]	

This solution was magnetically stirred overnight. Spin coating was done using a Brewer Science Inc. Model-100CB combination spin coater/hotplate on a 6 in. diameter silicon wafer, Type "P", 1.00 orient. Development was performed on a Litho Tech Japan, Resist Development Analyzer (RDA-790).

The wafer was prepared by depositing 6.0 ml of hexamethyldisilazane (HMDS) primer and spinning at 1000 rpm for 5 sec. Then 6.0 ml of the above solution was deposited and spun at 4500 rpm for 60 sec. and baked at 90°C for 60 sec. The coating was exposed to broadband UV light (200 to 450 nm) with an ORIEL Model-82421 Solar Simulator 1000 watt for 40 sec. through a UV photomask on quartz that is effective in blocking UV light in masked portions throughout the UV. The exposed wafer was baked at 90°C for 90 sec., and then developed for 20 sec. in tetramethyl ammonium hydroxide (TMAH) solution (ONKA NMD-3, 2.38% aqueous TMAH) to give a positive image.

EXAMPLE 22

A photoresist composition was made at 26% solids as summarized below:

Component	Wt. (gm)
Graft Copolymer Solution (Example 12)	13.1
(70) IBA/(30) IBOMA/tBMA/TTA 51/41/8	
Propylene glycol methyl ether acetate (PGMEA)	16.9
Diaryl iodonium hexafluoroantimonate salt:	0.59
4-(2-hydroxyl-1-tetradecyloxyphenyl) phenyl iodonium hexafluoroantimonate [Sartomer SarCar™ CD-1012 solid]	

This solution was magnetically stirred overnight. Spin coating was done using a Brewer Science Inc. Model-100CB combination spin coater/hotplate on a 6 in. diameter silicon wafer, Type "P", 1.00 orient. Development was performed on a Litho Tech Japan Co. Resist Development Analyzer (Model-790).

The wafer was prepared by depositing 6.0 ml of hexamethyldisilazane (HMDS) primer and spinning at 1000 rpm for 5 sec. Then 6.0 ml of the above solution was deposited and spun at 4500 rpm for 60 sec. and baked at 90°C for 60 sec. The coating was exposed to broadband UV light (200 to 450 nm) with an ORIEL Model-82421 Solar Simulator 1000 watt. Exposure time was 20 sec

through a mask with 18 positions of varying neutral optical density to allow various exposure doses. The exposed wafer was baked at 90°C for 90 sec., and then developed in tetramethylammonium hydroxide (TMAH) solution (ONKA NMD-3, 2.38% TMAH solution) to give a positive image.

- 5 The resist coating was of good quality, and developed cleanly in 20 sec.

EXAMPLE 23

- A photoresist composition was made at 26% solids as in Example 22, except that 12.9 gm of a solution of the random copolymer of Example 13, with the same overall composition of the graft copolymer of Example 12, was used in
10 place of the graft copolymer solution of Example 12, and 17.1 gm of PGMEA was used. The photoresist was processed as in Example 22 to give a positive image. The resist coating quality was good. However, compared to the resist sample in Example 22, the resist developed more slowly (60 sec vs. 20 sec) and line edge quality was more ragged.

- 15 EXAMPLE 24

- A photoresist composition was made at 26% solids as in Example 22, except that 12.0 gm of a solution of the graft copolymer of Example 15 was used in place of the graft copolymer solution of Example 12, and 18.0 gm of PGMEA was used. The photoresist was processed as in Example 22 to give a positive
20 image. The resist coating was of good quality, and developed cleanly in 20 sec although line edge quality was not as good as in Example 22.

EXAMPLE 25

- A photoresist composition was made at 26% solids as in Example 22, except that 15.4 gm of a solution of the graft copolymer of Example 17 was used
25 in place of the graft copolymer solution of Example 12, and 14.6 gm of PGMEA was used. The photoresist was processed as in Example 22 to give a positive image. Resist coating quality was cloudy and nonuniform, but it did develop in 60 sec., and better than the corresponding random polymer in Example 27.

EXAMPLE 26

- A photoresist composition was made at 26% solids as in Example 22, except that 18.4 gm of a solution of the random copolymer of Example 18, which has the same overall composition of the graft copolymer of Example 17, was used in place of the graft copolymer solution of Example 12, and 11.6 gm of PGMEA was used. The photoresist was processed as in Example 22 to give a positive
30 image. Resist coating quality was much poorer, and imaging/development was significantly poorer, than the graft copolymer in Example 26.

EXAMPLE 27

A photoresist composition was made at 26% solids as in Example 22, except that 11.6 gm of a solution of the graft copolymer of Example 6 was used in place of the graft copolymer solution of Example 12, and 18.4 gm of PGMEA and 0.38 gm of CD-1012 were used. The photoresist was processed as in Example 22 to give a positive image. The resist took longer to expose and develop than the resist in Example 22, and did not give as good an image or clean development.

EXAMPLE 28

A photoresist composition was made at 26% solids as in Example 22, except that 11.6 gm of a solution of the graft copolymer of Example 9 was used in place of the graft copolymer solution of Example 12, 18.4 gm of PGMEA and 0.38 gm of CD-1012 were used. The photoresist was processed as in Example 22 to give a positive image, with the exceptions that spin speed was 5500 rpm, exposure time was 180 sec, and time in the developer was 300 sec. The resist took longer to expose (180 sec) and develop (125 sec) than the resist of Example 22, but did develop cleanly and gave a very smooth coating.

EXAMPLE 29Measurement of Optical Transparency at 248 and 193 nm

Films of the random copolymer from Example 3 and the graft copolymer from Example 2 with the same composition, and the block copolymer from Example 4 with similar composition, were spin coated from solutions of these polymers, diluted to 20-30% solids with PGMEA, onto quartz substrates (1.5" x 1.0" x 0.09" thick; polished on both sides) with no HMDS primer at 4000 rpm for 60 sec, and were dried at 100°C for 60 sec. on a static hot plate. Dry thicknesses were measured by a Sloan Dektak II instrument to be about 2.6 μ . Absorption was measured on a Perkin-Elmer UV-Vis Lambda 9 spectrophotometer. Absorbance values (μm^{-1}) are plotted versus wavelength in Figure 1. This plot shows the low absorbance at 193 nm of the graft copolymer relative to the random polymer of same overall composition, and relative to the block copolymer of similar composition. Absorbance at 248 nm is negligible for all three polymers.

EXAMPLE 30

Two graft copolymers, and the corresponding random copolymers with the same overall composition, are prepared. Thus, graft copolymer 30-A, (67) IBA/(33) IBOMA/tBMA 64/36, is prepared in a manner similar to Example 2 with the appropriate macromonomer, and the random copolymer 30-B, 67/21/12 IBA/IBOMA/tBMA, is prepared in a manner similar to Example 3. Likewise, graft copolymer 30-C, (68) IBA/(32) IBOMA/tMBA/ITA 72/19/9, is prepared in a manner similar to Example 12 with the appropriate macromonomer, and the random

- copolymer 30-D, 68/23/6/3 IBA/IBOMA/tBMA/ITA, is prepared in a manner similar to Example 13. Photoresist compositions are prepared as in Examples 22 and 23, using 7.5 gm of each polymer (dry weight basis), 22.5 gm PGMEA, and 0.59 gm SarCat™ CD-1012. The formulations are processed as in Example 22, providing positive images, although the graft copolymers develop significantly faster than the respective random copolymers having the same overall composition, as indicated: 30-A vs. 30-B (60 sec vs. 78 sec), and 30-C vs. 30-D (25 sec vs. 150 sec).

EXAMPLE 31

Measurement of Plasma Etch Rates

- Polymer samples were dissolved in PGMEA to 20-30 weight % solids, and spin coated at 3000 rpm for 1 min. onto silicon wafers, and the coated wafer was then baked on a hot plate for 50 sec at 90°C. The plasma etch resistance of the spin coated polymers was then evaluated by exposure to a CF₄/O₂ plasma (pressure = 150 mtorr, CF₄/O₂ = 40/7.1 sccm, source power = 300 w, 483v DC Bias). The plasma etch rate was determined by protecting a portion of the coated wafer with a microscope slide or cover slip; the wafer was then exposed to the CF₄/O₂ plasma for a given length of time and the thickness change of the unprotected resist vs. resist protected under the glass slide was measured using an Alpha-Steco 200 Stylus Profilometer with a 5 μ tip stylus. The etch rate (in angstroms/minute) was usually measured at two different exposure times (e.g., 1.5 min. and 3.0 min.). For comparison purposes, results obtained for a commercial novolak resin (Borden Inc.) at two different exposure times are included, and the values obtained on a given day were used to give the relative etch rate data for other polymers measured on the same day. When several data exist, the etch rates and relative etch rates are average values.

Copolymer (Example #)	Weight % of Spin Coating Solution	Exposure Time in CF ₄ /O ₂ Plasma (min)	Etch Rate (Å/min)	Etch Rate Relative to Novolak
Borden Novolak	27	3.0	1291	--
PD-124C	(in 55/45 PGMEA/acetone)	1.5	1371	--
11	25	3.0	1904	1.5
		1.5	1384	1.2
6	25	3.0	1516	1.2
		1.5	1615	1.4
9	25	3.0	1487	1.2
		1.5	1549	1.3
3	25	3.0	1750	1.4
		1.5	1476	0.9

Copolymer (Example #)	Weight % of Spin Coating Solution	Exposure Time in CF ₄ /O ₂ Plasma (min)	Etch Rate (Å/min)	Etch Rate Relative to Novolak
2	25	3.0	1945	1.5
		1.5	1618	1.2
4	25	3.0	1875	1.6
		1.5	1667	1.1
33	25	3.0	1719	1.4
		1.5	1716	1.5

EXAMPLE 32

- A photoresist composition was made at 27% solids as in Example 22,
 5 except that 16.0 gm of a solution of the graft copolymer solution of Example 34
 was used in place of the graft copolymer solution of Example 12, and 14.0 gm of
 PGMEA and 0.00 gm of CD-1012 were used. The photoresist was processed as in
 Example 22 to give a positive image. Image quality and development were at
 least as good as those for Example 22.

EXAMPLE 33

- A photoacid generator (PAG) was attached to the arm of a graft copolymer
 in the following way. To a 500 ml three necked flask fitted with a reflux
 condenser and nitrogen bubbler, glass bladed Teflon® paddle stirrer, stainless steel
 thermocouple, heating mantle, and serum cap, was charged 137.2 gm graft
 15 copolymer solution of Example 11 and 35 ml methyl ethyl ketone (MEK), and the
 resulting mixture was stirred. To this was added with stirring 6.61 gm of 4-(2-
 hydroxy-1-tetradecyl-1-oxy)phenyl phenyl iodonium hexafluoroantimonate
 [Sartomer SarCat™ CD-1012 solid] which was rinsed with 26 ml of MEK. The
 solution was heated to about 57°C and held about four hours with stirring until the
 20 anhydride level was judged to be constant by periodically reacting small samples
 with an excess of n-butyl amine, and titrating the excess with 0.1 M aqueous
 HClO₄. This provided 154.8 gm of solution product measuring 50.29% Solids.

EXAMPLE 34

- A photoresist composition was made at 28% solids as in Example 22,
 25 except that 12.8 gm of a solution of the graft copolymer of Example 11 was used
 in place of the graft copolymer solution of Example 12, 17.2 gm of PGMEA and
 0.60 gm of CD-1012 were used. The photoresist was processed as in Example 22
 to give a positive image.

EXAMPLE 35IBOMA/tBMA 60/40 Macromonomer

- The macromonomer is prepared by charging the following components to a 1 liter flask equipped with a thermocouple, stirrer, dropping funnels, reflux condenser, and the means for bubbling nitrogen through the reaction.

	Parts by Weight	Grams
Portion 1		
t-butyl methacrylate (tBMA)		51.96
Isobornyl methacrylate (IBOMA)		77.94
Methyl ethyl ketone (MEK)		168.74
Portion 2		
Methylethyl ketone (MEK)		17.41
Isopropyl-bis(borondifluorodimethylglyoximate)		
cobaltate (III) Catalyst (DMG Co(III))		0.004
VAZO®52 Initiator		0.13
Portion 3		
Methyl ethyl ketone (MEK)		10.13
Portion 4		
DMG Co (III) Catalyst		0.004
VAZO®52 Initiator		1.43
Methylethyl ketone		52.09
Portion 5		
t-butyl methacrylate (tBMA)		48.06
Isobornyl methacrylate (IBOMA)		72.10
Total		500.00

- Portion 1 is heated to its reflux temperature in about 15 minutes. Portion 2 is thoroughly mixed and is added as shot and the composition is held at its reflux temperature for 5 minutes. The vessel which contained Portion 2 is rinsed with Portion 3, which is then added to the reaction vessel along with Portion 2. Portions 4 and 5 are mixed and then added simultaneously to the reaction vessel while the vessel is maintained its reflux temperature. For Portion 4, the first 54.8% is added over 90 minutes, and the remaining 45.2% is added over 240 minutes. For Portion 5, the first 67% is added over 120 minutes, and the remaining 33% is added over an additional 120 minutes. After Portions 4 and 5 are added to the vessel, the reaction is held at reflux for an additional 45 minutes. After the 45 minute hold, the reaction is cooled to room temperature.

The resulting macromonomer solution has a solids content of approximately 49%, a M_n of approximately 5700, and a polydispersity of approximately 2.

EXAMPLE 36

5 (70)IBA/(30)IBOMA/tBMA 60/40 Graft Copolymer

The macromonomer prepared in Example 35 is used in the following graft copolymer synthesis. The following components are charged into a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
Macromonomer (Example 35)		203.43
Isobornyl acrylate (IBA)		36.35
MEK		51.00
Portion 2		
t-butyl peroxyvalate		2.21
MEK		11.64
Portion 3		
IBA		162.28
Portion 4		
t-butyl peroxyvalate		2.21
MEK		22.06
Portion 5		
t-butyl peroxyvalate		4.41
MEK		4.41
Total		500.00

- 10 Portion 1 is heated to reflux temperature over a period of approximately 20 minutes. Portion 2 is mixed and charged to the reactor in two equal portions - after the first is added, the reaction is held at reflux for 10 minutes before the second half is added. After the second half of Portion 2 is added, the reaction is
- 15 held at reflux for 10 minutes. After the hold, Portions 3 and 4 are each added simultaneously to the reaction vessel while maintaining its contents at reflux. Portion 3 is added over 180 minutes, and Portion 4 is added over 240 minutes. After the additions of Portions 3 and 4 are completed, Portion 5 is thoroughly mixed and added to the reaction vessel over 15 minutes, maintaining the reflux
- 20 temperature. After the addition of Portion 5 is completed, the reaction mixture is maintained at reflux for 120 minutes and then cooled to room temperature. The

resulting graft copolymer solution has a solids content of approximately 60%, a M_w of approximately 16,000 and a dispersity of approximately 2.4.

EXAMPLE 37

IBA/tBMA/HEMA 85.4/7.3/7.3 Random Copolymer

- 5 The following components were charged in a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
tBMA		2.41
IBA		28.17
HEMA		2.41
MEK		49.42
Portion 2		
IBA		112.69
tBMA		9.62
HEMA		9.62
Portion 3		
Vazo®52 Initiator		3.29
MEK		82.37
Total		300.00

- 10 Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. At reflux 10% of portion 3 was added to the reaction flask. After a 5 minute hold the remainder of portion 3 was added over 270 minutes while part 2 was being added over 240 minutes. At the end of both feeds the reaction mixture was held at reflux for an additional 30 minutes. The resulting random copolymer solution had a solids content of 55.90%, a M_w of 13,200 and a dispersity of 2.16.

- 15 EXAMPLE 38

IBOMA/tBMA/HEMA 60/20/20 Random Copolymer

The following components were charged in a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
tBMA		6.59
IBOMA		28.17
HEMA		6.59
MEK		49.45
Portion 2		
IBOMA		79.12
TBMA		26.37
HEMA		26.37
Portion 3		
Vazo® 52 Initiator		3.30
MEK		82.42
Total		300.00

- Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. At reflux 10% of portion 3 was added to the reaction flask. After a 5 minute hold the remainder of portion 3 was added over 270 minutes while part 2
- 5 was being added over 240 minutes. At the end of both feeds the reaction mixture was held at reflux for an additional 30 minutes. The resulting random copolymer solution had a solids content of 55.18%, a M_w of 15,100 and a dispersity of 2.19.

EXAMPLE 39

IBA/IBOMA/HEMA 74.5/19.1/6.4 Random Copolymer

- 10 The following components were charged in a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
IBA		24.56
IBOMA		6.3
HEMA		2.11
MEK		49.45
Portion 2		
IBOMA		25.22
IBA		98.23
HEMA		8.44

	Parts by Weight	Grams
Portion 3		
Vazo®52 Initiator		3.30
MEK		82.41
Total		300.00

- Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. At reflux 10% of portion 3 was added to the reaction flask. After a 5 minute hold the remainder of portion 3 was added over 270 minutes while part 2 was being added over 240 minutes. At the end of both feeds the reaction mixture was held at reflux for an additional 30 minutes. The resulting random copolymer solution had a solids content of 55.95%, a M_w of 12,700 and a dispersity of 2.09.

EXAMPLE 40

IBA/IBOMA/tBMA 76/18/6 Random Copolymer

The following components were charged in a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
IBA		41.76
IBOMA		9.89
tBMA		3.30
MEK		82.42
Portion 2		
IBOMA		39.56
IBA		167.03
tBMA		13.19
Portion 3		
MEK		137.36
Total		500.00

- Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. At reflux 10% of portion 3 was added to the reaction flask. After a 5 minute hold the remainder of portion 3 was added over 270 minutes while part 2 was being added over 240 minutes. At the end of both feeds the reaction mixture was held at reflux for an additional 30 minutes. The resulting random copolymer solution had a solids content of 58.88%, a M_w of 16,200 and a dispersity of 2.39.

EXAMPLE 41IBA Homopolymer

The following components were charged in a 1 liter flask equipped as in Example 1.

5

	Parts by Weight	Grams
Portion 1		
IBA		54.95
MEK		82.42
Portion 2		
IBA		219.78
Portion 3		
Vazo®52 Initiator		5.49
MEK		137.36
Total		500.00

Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. At reflux 10% of portion 3 was added to the reaction flask. After a 5 minute hold the remainder of portion 3 was added over 270 minutes while part 2
10 was being added over 240 minutes. At the end of both feeds the reaction mixture was held at reflux for an additional 30 minutes. The resulting random copolymer solution had a solids content of 53.60%, a M_w of 13,700 and a dispersity of 2.15.

EXAMPLE 42

A photoresist composition is made at 26% solids as in Example 22, except
15 that 12.2 gm of a solution of the graft copolymer of Example 36 is used in place of the graft copolymer solution of Example 22, and 17.8 gm of PGMEA is used. The photoresist is processed as in Example 22 to give a positive image. The resist coating is of good quality, and develops cleanly.

EXAMPLE 43

This example illustrates a photoresist of the invention that contains a dissolution inhibitor. A photoresist composition is made at 26% solids as in Example 22, except that the following are used: 10.5 gm of the graft copolymer solution of Example 12, 1.5 gm of tert-butyl lithocholate, and 18.0 gm of PGMEA. The photoresist is processed as in Example 22 to give a positive image.
25 The resist coating is of good quality and develops cleanly.

EXAMPLE 44Effect of Monomer Composition on OpticalTransparency in the DUV:

- The random copolymers of Examples 37-41 were diluted and coated as in
- 5 Example 29 to test the effect of monomer composition on optical transparency in the EUV (193 nm). Comparison of the spectra indicate that methacrylate monomers increase absorbance of the resulting more than do acrylate monomers. It is also indicated that these monomers types should be separated for reduced absorbance, such as in different segments of the graft copolymer, as demonstrated
- 10 in Example 29 and Fig. 1.

EXAMPLE 45AMMA/tBMA/MAA 40/40/20 Macromonomer

- The macromonomer was prepared by charging the following components to a 1 liter flask equipped with a thermocouple, stirrer, dropping funnels, reflux
- 15 condenser, and the means for bubbling nitrogen through the reaction.

Parts by Weight	Grams
Portion 1	
t-butyl methacrylate (tBMA)	184.21
Methyl methacrylate (MMA)	184.21
Methacrylic acid (MAA)	61.60
Isopropanol (IPRAL)	519.60
Portion 2	
Methylethyl ketone (MEK)	16.08
Isopropanol (IPRAL)	37.52
Isopropyl-bis(borondifluorodimethylglyoximate)cobaltate (III)	0.02
Catalyst (DMG Co(III))	
VAZO®52 Initiator	0.40
Portion 3	
Isopropanol (IPRAL)	31.20
Portion 4	
Methylethyl ketone (MEK)	48.12
DMG Co (III) Catalyst	0.04
VAZO®52 Initiator	4.40
Isopropanol (IPRAL)	112.28

	Parts by Weight	Grams
Portion 5		
t-butyl methacrylate (tBMA)		123.21
Methyl methacrylate (MMA)		123.21
Methacrylic acid (MAA)		92.40
Total		500.00

Portion 1 was heated to its reflux temperature in about 15 minutes.

- Portion 2 was thoroughly mixed and added as shot and the composition was held at its reflux temperature for 5 minutes. The vessel which contained Portion 2 was rinsed with Portion 3, which was then added to the reaction vessel along with Portion 2. Portions 4 and 5 were mixed and then added simultaneously to the reaction vessel while the vessel maintained its reflux temperature. For Portion 4, the first 54.8% was added over 90 minutes, and the remaining 45.2% was added over 240 minutes. For Portion 5, the first 67% was added over 120 minutes, and the remaining 33% was added over an additional 120 minutes. After Portions 4 and 5 were added to the vessel, the reaction was held at reflux for an additional 45 minutes. After the 45 minute hold, the reaction was cooled to room temperature.

- The resulting macromonomer solution had a solids content of 50.33%, a M_n of 3181 and a polydispersity of 1.98.

EXAMPLE 45B

(70)IBA/MA/AA/tBA 70/10/10/10/(30)MMA/tBMA/MAA 40/40/20

Graft Copolymer

- The macromonomer prepared in Example 45A was used in the following graft co-polymer synthesis. The following components were charged into a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
Macromonomer (Example 10A)		169.56
Isobornyl acrylate (IBA)		25.52
Methyl acrylate (MA)		3.65
Acrylic acid (AA)		3.65
t-Butyl acrylate (tBA)		3.65
MEK		84.23

	Parts by Weight	Grams
Portion 2		
t-butyl peroxydipivalate		2.21
MEK		11.67
Portion 3		
Isobornyl acrylate (IBA)		113.89
Methyl acrylate (MA)		16.27
Acrylic acid (AA)		16.27
t-Butyl acrylate (tBA)		16.27
Portion 4		
t-butyl peroxydipivalate		2.21
MEK		22.12
Portion 5		
t-butyl peroxydipivalate		4.42
MEK		4.42
Total		500.00

- Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. Portion 2 was mixed and charged to the reactor in two equal portions
- 5 - after the first was added, the reaction was held at reflux for 10 minutes before the second half was added. After the second half of Portion 2 was added, the reaction was held at reflux for 10 minutes. After the hold, Portions 3 and 4 were each added simultaneously to the reaction vessel while maintaining its contents at reflux. Portion 3 was added over 180 minutes, and Portion 4 was added over
- 10 180 minutes. After the additions of Portions 3 and 4 were completed, hold at reflux for 60 minutes. Then Portion 5 was thoroughly mixed and added to the reaction vessel over 30 minutes, maintaining the reflux temperature. After the addition of Portion 5 was completed, the reaction mixture was maintained at reflux for 60 minutes and then cooled to room temperature. The resulting graft
- 15 copolymer solution had a solids content of 60.3%, a M_w of 11607 and a polydispersity of 2.35.

EXAMPLE 46

(70)IBA/AA 85/15/(30)MMA/tBMA/MAA 40/40/20 Graft Copolymer

- The macromonomer prepared in Example 45A was used in the following
- 20 graft co-polymer synthesis. The following components were charged into a 1 liter flask equipped as in Example 1.

Parts by Weight		Grams
Portion 1		
Macromonomer (Example 10A)		169.56
Isobornyl acrylate (IBA)		30.98
Acrylic acid (AA)		5.47
MEK		84.23
Portion 2		
t-butyl peroxyphthalate		2.21
MEK		11.67
Portion 3		
Isobornyl acrylate (IBA)		138.30
Acrylic acid (AA)		24.41
Portion 4		
t-butyl peroxyphthalate		2.21
MEK		22.12
Portion 5		
t-butyl peroxyphthalate		4.42
MEK		4.42
Total		500.00

- Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. Portion 2 was mixed and charged to the reactor in two equal portions - after the first was added, the reaction was held at reflux for 10 minutes before the
- 5 second half was added. After the second half of Portion 2 was added, the reaction was held at reflux for 10 minutes. After the hold, Portions 3 and 4 were each added simultaneously to the reaction vessel while maintaining its contents at reflux. Portion 3 was added over 180 minutes, and Portion 4 was added over 180 minutes. After the additions of Portions 3 and 4 were completed, hold at
- 10 reflux for 60 minutes. Then Portion 5 was thoroughly mixed and added to the reaction vessel over 30 minutes, maintaining the reflux temperature. After the addition of Portion 5 was completed, the reaction mixture was maintained at reflux for 60 minutes and then cooled to room temperature. The resulting graft copolymer solution had a solids content of 60.7%, a M_w of 10350 and a
- 15 polydispersity of 2.78.

EXAMPLE 47

(70)IBA/MA/AA 80/10/10/(30)MMA/tBMA/MAA 40/40/20 Graft Copolymer

- The macromonomer prepared in Example 45A was used in the following graft co-polymer synthesis. The following components were charged into a 1 liter
- 20 flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
Macromonomer (Example 10A)		169.56
Isobornyl acrylate (IBA)		23.69
Methyl acrylate (MA)		3.64
Acrylic acid (AA)		3.64
MEK		84.23
Portion 2		
t-butyl peroxyphthalate		2.21
MEK		11.67
Portion 3		
Isobornyl acrylate (IBA)		130.14
Methyl acrylate (MA)		16.27
Acrylic acid (AA)		16.27
Portion 4		
t-butyl peroxyphthalate		2.21
MEK		22.12
Portion 5		
t-butyl peroxyphthalate		4.42
MEK		4.42
Total		500.00

- Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. Portion 2 was mixed and charged to the reactor in two equal portions
- 5 - after the first was added, the reaction was held at reflux for 10 minutes before the second half was added. After the second half of Portion 2 was added, the reaction was held at reflux for 10 minutes. After the hold, Portions 3 and 4 were each added simultaneously to the reaction vessel while maintaining its contents at reflux. Portion 3 was added over 180 minutes, and Portion 4 was added over
- 10 180 minutes. After the additions of Portions 3 and 4 were completed, hold at reflux for 60 minutes. Then Portion 5 was thoroughly mixed and added to the reaction vessel over 30 minutes, maintaining the reflux temperature. After the addition of Portion 5 was completed, the reaction mixture was maintained at reflux for 60 minutes and then cooled to room temperature. The resulting graft
- 15 copolymer solution had a solids content of 65.9%, a M_w of 6246 and a polydispersity of 2.0.

EXAMPLE 48(70)IBA/AN/AA 65/20/15/(30)MMA/tBMA/MAA 40/40/20 Graft Copolymer

- The macromonomer prepared in Example 45A was used in the following graft co-polymer synthesis. The following components were charged into a 1 liter flask equipped as in Example 1.

Parts by Weight	Grams
Portion 1	
Macromonomer (Example 10A)	169.56
Isobornyl acrylate (IBA)	23.69
Acrylonitrile	7.29
Acrylic acid (AA)	5.47
MEK	84.23
Portion 2	
t-butyl peroxyvalerate	2.21
MEK	11.67
Portion 3	
Isobornyl acrylate (IBA)	105.76
Acrylonitrile (AN)	32.54
Acrylic acid (AA)	24.41
Portion 4	
t-butyl peroxyvalerate	2.21
MEK	22.12
Portion 5	
t-butyl peroxyvalerate	4.42
MEK	4.42
Total	500.00

- Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. Portion 2 was mixed and charged to the reactor in two equal portions
- 10 - after the first was added, the reaction was held at reflux for 10 minutes before the second half was added. After the second half of Portion 2 was added, the reaction was held at reflux for 10 minutes. After the hold, Portions 3 and 4 were each added simultaneously to the reaction vessel while maintaining its contents at reflux. Portion 3 was added over 180 minutes, and Portion 4 was added over
- 15 180 minutes. After the additions of Portions 3 and 4 were completed, hold at reflux for 60 minutes. Then Portion 5 was thoroughly mixed and added to the reaction vessel over 30 minutes, maintaining the reflux temperature. After the addition of Portion 5 was completed, the reaction mixture was maintained at

- reflux for 60 minutes and then cooled to room temperature. To remove the residual acrylonitrile, the MEK was stripped at reflux temperature until the temperature was reached 83.9°C. Then 258 gm of PGMEA (propylene glycol monomethyl ether acetate) was added and the resulting solution was concentrated by using a rotavap. The resulting graft copolymer solution had a solids content of 61.0%, a M_w of 16943 and a polydispersity of 2.55.

EXAMPLE 49

(70)IBA/(30)MMA/tBMA/MAA 40/40/20 Graft Copolymer

- The macromonomer prepared in Example 45A was used in the following graft co-polymer synthesis. The following components were charged into a 1 liter flask equipped as in Example 1.

	Parts by Weight	Grams
Portion 1		
Macromonomer (Example 10A)		169.56
Isobornyl acrylate (IBA)		36.45
MEK		84.23
Portion 2		
t-butyl peroxyphthalate		2.21
MEK		11.67
Portion 3		
Isobornyl acrylate (IBA)		162.70
Portion 4		
t-butyl peroxyphthalate		2.21
MEK		22.12
Portion 5		
t-butyl peroxyphthalate		4.42
MEK		4.42
Total		500.00

- Portion 1 was heated to reflux temperature over a period of approximately 20 minutes. Portion 2 was mixed and charged to the reactor in two equal portions - after the first was added, the reaction was held at reflux for 10 minutes before the second half was added. After the second half of Portion 2 was added, the reaction was held at reflux for 10 minutes. After the hold, Portions 3 and 4 were each added simultaneously to the reaction vessel while maintaining its contents at reflux. Portion 3 was added over 180 minutes, and Portion 4 was added over 180 minutes. After the additions of Portions 3 and 4 were completed, hold at reflux for 60 minutes. Then Portion 5 was thoroughly mixed and added to the

- reaction vessel over 30 minutes, maintaining the reflux temperature. After the addition of Portion 5 was completed, the reaction mixture was maintained at reflux for 60 minutes and then cooled to room temperature. The resulting graft copolymer solution had a solids content of 59.2%, a M_w of 7562 and a polydispersity of 2.61.

EXAMPLE 50

The following formulation was prepared and magnetically stirred overnight.

	<u>Component</u>	<u>Wt. (gm)</u>
10	Copolymer described in Example 45, [70] IBA/MA/tBA/AA 70/10/10/10 // [30] MMA/tBMA/MAA 40/40/20, which had been solvent exchanged with 15 PGMEA as follows. Thus, to 100.0 gm of the copolymer solution in Example 45 (60.3% Solids in MEK) was added 140.7 gm PGMEA, and rotary evaporated under vacuum to a net weight of 201.0 gm (30% Solids)	7.3
20	Propylene glycol methyl ether acetate (PGMEA)	5.3
	Cyclohexanone	7.5
	t-Butyl Lithocholate	2.18
25	5% (wt) solution of triphenylsulfonium triflate dissolved in cyclohexanone which was filtered through a 0.45 μ PTFE syringe filter.	2.70

- Spin coating of the above formulation was done using a Brewer Science Inc. Model-100CB combination spin coater/hotplate on a 4 in. diameter silicon wafer, Type "P", 1.00 orient. Development was performed on a Litho Tech Japan Co. Resist Development Analyzer (Model-790).

- The wafer was prepared by depositing 4 ml of hexamethyldisilazane (HMDS) primer and spinning at 1000 rpm for 5 sec. and then 3500 rpm for 10 sec. Then 4 ml of the above formulation, after filtering through a 0.45 μ PTFE syringe filter, was deposited and spun at 3000 rpm for 60 seconds and baked at 120°C for 60 seconds. The coated wafer was exposed to 248 nm light obtained by passing broadband UV light from an ORIEL Model-82421 Solar Simulator (1000 watt) through a 248 nm interference filter which passes about 30% of the energy at 248 nm. Exposure time was 5 seconds, providing a dose of 3.4 mJ/cm², through a

mask with 18 positions of varying neutral optical density to allow various exposure doses. The exposed wafer was then baked at 120°C for 120 seconds. The wafer was developed for 10 seconds in aqueous tetramethylammonium hydroxide (TMAH) solution (ONKA NMD-W, 2.38% TMAH solution) to give a positive image.

EXAMPLE 51

The following formulation was prepared and magnetically stirred overnight.

	<u>Component</u>	<u>Wt. (gm)</u>
10	Copolymer described in Example 46, [70] IBA/AA 85/15 // [30] MMA/tBMA/MAA 40/40/20, which had been solvent exchanged with	
15	PGMEA as follows. Thus, to 50.0 gm of the copolymer solution in Example 46 (60.7% Solids in MEK) was added 19.7 gm PGMEA, and rotary evaporated under vacuum to a net weight of 49.9 gm	
20	(60.8% Solids).	5.3
	Propylene glycol methyl ether acetate (PGMEA)	15.8
	t-Butyl Lithocholate	1.13
25	5% (wt) solution of triphenylsulfonium triflate dissolved in cyclohexanone which was filtered through a 0.45 μ PTFE syringe filter	2.8

The above formulation was processed as in Example 50 to give a positive image.

EXAMPLE 52

The following formulation was prepared and magnetically stirred overnight.

	<u>Component</u>	<u>Wt. (gm)</u>
	Copolymer described in Example 47, [70] IBA/MA/AA 80/10/10 //	
	[30] MMA/TBMA/MAA 40/40/20,	
5	which had been solvent exchanged with PGMEA as follows. Thus, to 100.0 gm of the copolymer solution in Example 47 (65.9% Solids in MEK) was added 153.8 gm PGMEA, and rotary evaporated under	
10	vacuum to a net weight of 219.7 gm (30% Solids)	7.3
	Propylene glycol methyl ether acetate (PGMEA)	5.3
	Cyclohexanone	7.5
15	t-Butyl Lithocholate	2.18
	5% (wt) solution of triphenylsulfonium triflate dissolved in cyclohexanone which was filtered through a 0.45 μ PTFE syringe filter	2.70
20	The above formulation was processed as in Example 50, except that an exposure time of 30 seconds providing a dose of 20.4 mJ/cm ² was used, to give a positive image.	

EXAMPLE 53

25 The following formulation was prepared and magnetically stirred overnight.

	<u>Component</u>	<u>Wt. (gm)</u>
	Copolymer described in Example 48, [70] IBA/AN/AA 65/20/15 //	
	[30] MMA/tBMA/MAA 40/40/20,	
30	which had been additionally solvent exchanged with PGMEA as follows. Thus, to 100.0 gm of the copolymer solution in Example 48 (61.0% Solids) was added 140.2 gm PGMEA, and rotary evaporated	
35	under vacuum to a net weight of 200.3 gm (30.5% Solids)	7.3
	Propylene glycol methyl ether acetate (PGMEA)	5.3

	<u>Component</u>	<u>Wt. (gm)</u>
	Cyclohexanone	12.5
	t-Butyl Lithocholate	2.18
5	5% (wt) solution of triphenylsulfonium triflate dissolved in cyclohexanone which was filtered through a 0.45 μ PTFE syringe filter	2.70

The above formulation was processed as in Example 50, except that an exposure of
 10 20 seconds providing a dose of 13.6 mJ/cm² and a 30 second development time were used,
 to obtain a positive image.

EXAMPLE 54

The following solution was prepared and magnetically stirred overnight.

	<u>Component</u>	<u>Wt. (gm)</u>
15	Copolymer described in Example 49, [70] IBA 100 // [30] MMA/tBMA/MAA 40/40/20, which had been solvent exchanged with PGMEA as follows. Thus, to 100.0 gm of the copolymer solution in Example 49 (59.2% Solids in MEK) was added 40.8 gm PGMEA, and rotoary evaporated under vacuum to a net weight of 99.8 gm 25 (59.3% Solids).	5.5
	Propylene glycol methyl ether acetate (PGMEA)	15.7
	t-Butyl Lithocholate	1.13
30	5% (wt) solution of triphenylsulfonium triflate dissolved in cyclohexanone which was filtered through a 0.45 μ PTFE syringe filter	2.70

The above formulation was processed as in Example 50 to give a positive
 image.

35

What is claimed is:

1. A positive-working photoresist comprising:

(A) a branched polymer containing protected acid groups, said polymer comprising one or more branch segment(s) chemically linked along a linear backbone segment, wherein the branch segment(s) contain at least two repeating monomer units and have a number average molecular weight (M_n) of at least 1000; and

(B) at least one photoacid generator.

2. The photoresist of Claim 1 wherein one of the segments contains greater than 50% of the protected acid groups present in the branched polymer.

3. The photoresist of Claim 2 wherein the branch segment(s) contains greater than 50% of the protected acid groups present in the branched polymer.

4. The photoresist of Claim 1 wherein the branched polymer contains functional groups that are compatible with the photoacid generator, said functional groups being distributed in the branched polymer such that 25 to 100% of the functional groups are present in the segment of the branched polymer containing a majority of the protected acid groups.

5. The photoresist of Claim 1 wherein the photoacid generator is covalently bonded to the branched polymer.

6. The photoresist of Claim 5 wherein the photoacid generator is covalently bonded to the branch segment(s).

7. The photoresist of Claim 6 wherein one of the segments contains greater than 50% of the protected acid groups present in the branched polymer.

8. The photoresist of Claim 7 wherein the branch segment(s) contain greater than 50% of the protected acid groups present in the branched polymer.

9. The photoresist of Claim 1 wherein the branched polymer is comprised of an acrylate polymer, a methacrylate polymer, an acrylate/methacrylate copolymer, and combinations thereof.

10. The photoresist of Claim 1 further comprising a solvent.

11. The photoresist of Claim 1 wherein the branched polymer is formed by addition polymerization of at least one ethylenically unsaturated macromer component and at least one ethylenically unsaturated comonomer.

12. The photoresist of Claim 1 wherein the branched polymer segment is attached to a preformed linear backbone by chemical reaction.

13. The photoresist of Claim 11 wherein

(a) the ethylenically unsaturated macromonomer component has a number average molecular weight (M_n) in the range of 1000 to 15,000;

5 (b) the linear backbone segment has a number average molecular weight (M_n) between 2,000 and 500,000; and

(c) the weight ratio of the linear backbone segment to the branch segment(s) is within a range of 50/1 to 1/10.

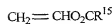
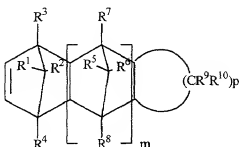
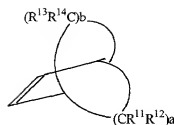
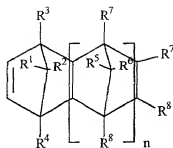
14. The photoresist of Claim 1 wherein the branched polymer has a glass transition temperature of at least 22°C.

10 15. The photoresist of Claim 1 further comprising a dissolution inhibitor.

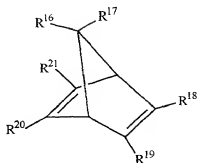
16. The photoresist of Claim 1 wherein the branched polymer is an acrylic/methacrylic/styrenic copolymer being at least 60% by weight acrylate and having at least 60% of methacrylate repeat units present either in a first location or a second location, the first location being one of the segments, the second location
15 being a segment different from the first location, wherein at least 60% of the acrylate repeat units are present in the second location.

17. The photoresist of Claim 1 wherein the branched polymer is a fluorine-containing copolymer comprising a repeat unit derived from at least one ethylenically unsaturated compound containing at least one fluorine atom
20 covalently attached to an ethylenically unsaturated carbon atom.

18. The photoresist of Claim 17 wherein the fluorine-containing copolymer is further comprised of a repeat unit derived from at least one unsaturated compound selected from the group consisting of:



and



wherein:

each of m and n is 0, 1 or 2, p is an integer of at least 3;

- 5 a and b are independently 1 to 3 except that a is not = 1 when b = 2 or vice versa;

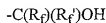
R¹ to R¹⁴ are the same or different and each represents a hydrogen atom, a halogen atom, a carboxyl group, a C₁ to C₁₄ secondary or tertiary alkyl carboxylate, a hydrocarbon group or a substituted hydrocarbon group;

- 10 R¹⁵ is a saturated alkyl group of about 4 to 20 carbon atoms, optionally containing one or more ether oxygens with the proviso that the ratio of carbon atoms to hydrogen atoms is greater than or equal to 0.58; and

R¹⁶ to R²¹ are each independently hydrogen atoms, C₁ to C₁₂ alkyls, (CH₂)_qCO₂A, CO₂(CH₂)_qCO₂A or CO₂A wherein q is 1 to 12 and A is hydrogen

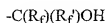
or an acid protecting group with the proviso that at least one of R¹⁸ to R²¹ is CO₂A.

19. The photoresist of Claim 18 wherein the fluorine-containing copolymer further comprises a repeat unit derived from at least one ethylenically unsaturated compound containing a fluoroalcohol functional group having the structure:



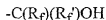
- 10 wherein R_f and R_f' are the same or different fluoroalkyl groups of from 1 to about 10 carbon atoms or taken together are (CF₂)_n wherein n is 2 to 10.

20. The photoresist of Claim 17 wherein the fluorine-containing copolymer further comprises a repeat unit derived from at least one ethylenically unsaturated compound containing a fluoroalcohol functional group having the structure:



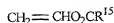
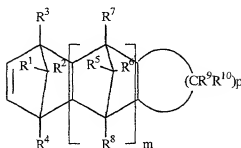
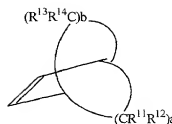
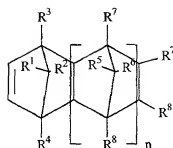
- 20 wherein R_f and R_f' are the same or different fluoroalkyl groups of from 1 to about 10 carbon atoms or taken together are (CF₂)_n wherein n is 2 to 10.

21. The photoresist of Claim 1 wherein the branched polymer is a fluorine-containing copolymer comprising a repeat unit derived from at least one ethylenically unsaturated compound containing a fluoroalcohol functional group having the structure:

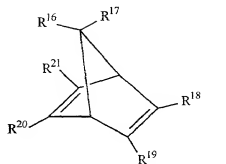


- 25 wherein R_f and R_f' are the same or different fluoroalkyl groups of from 1 to about 10 carbon atoms or taken together are (CF₂)_n wherein n is 2 to 10.

- 30 22. The photoresist of Claim 21 wherein the fluorine-containing copolymer is further comprised of a repeat unit derived from at least one unsaturated compound selected from the group consisting of:



and



wherein:

each of m and n is 0, 1 or 2, p is an integer of at least 3;

a and b are independently 1 to 3 except that a is not = 1 when b = 2 or vice versa;

- 5 R^1 to R^{14} are the same or different and each represents a hydrogen atom, a halogen atom, a carboxyl group, a C_1 to C_{14} secondary or tertiary alkyl carboxylate, a hydrocarbon group or a substituted hydrocarbon group;
- R^{15} is a saturated alkyl group of about 4 to 20 carbon atoms, optionally containing one or more ether oxygens with the proviso that the ratio of
- 10 carbon atoms to hydrogen atoms is greater than or equal to 0.58; and
- R^{16} to R^{21} are each independently hydrogen atoms, C_1 to C_{12} alkyls, $(\text{CH}_2)_q\text{CO}_2\text{A}$, $\text{CO}_2(\text{CH}_2)_q\text{CO}_2\text{A}$ or CO_2A wherein q is 1 to 12 and A is hydrogen or an acid protecting group with the proviso that at least one of R^{18} to R^{21} is CO_2A .

23. The photoresist of Claim 21 wherein the photoacid generator is covalently bonded to the branched polymer.

24. The photoresist of Claim 23 wherein the photoacid generator is covalently bonded to the branch segment(s).

5 25. The photoresist of Claim 24 wherein one of the segments contains greater than 50% of the protected acid groups present in the branched polymer.

26. The photoresist of Claim 25 wherein the branch segment(s) contain greater than 50% of the protected acid groups present in the branched polymer.

27. A process for preparing a photoresist image on a substrate comprising,
10 in order:

(W) applying a photoresist composition on a substrate, wherein the photoresist composition comprises:

(a) a branched polymer containing protected acid groups, said polymer comprising one or more branch segment(s) chemically linked along a
15 linear backbone segment, wherein the branched polymer contains sufficient functionality to render the photoresist developable to afford a relief image, upon imagewise exposure to radiation selected from the group consisting of ultraviolet and violet and subsequent heating, and wherein the branch segment(s) contain at least two repeating monomer units and have a number average molecular weight
20 (M_n) of at least 1000;

(b) at least one photoacid generator; and

(c) a solvent;

(X) drying the coated photoresist composition to remove solvent and thereby to form a photoresist layer on the substrate;

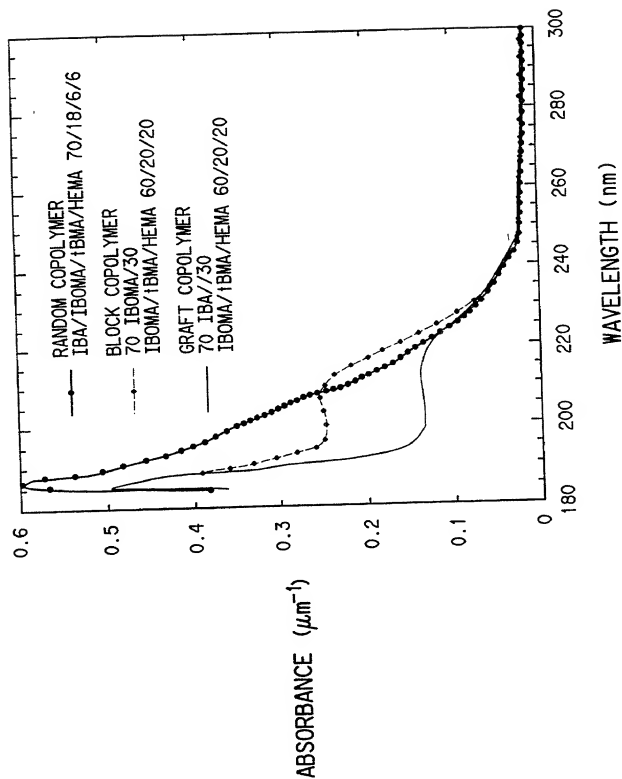
25 (Y) imagewise exposing the photoresist layer to form imaged and non-imaged areas; and

(Z) developing the exposed photoresist layer having images and non-imaged areas to form the relief image on the substrate.

28. The process of Claim 27 further comprising a step of heating the photoresist layer following step (X) and prior to step (Z).

29. The process of Claim 27 wherein the photoresist layer is developed with an aqueous alkaline developer.

FIG. 1



GENERAL POWER OF ATTORNEY
(Concerning Several International Patent Applications)

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Birch, Linda D.	38,719	Krukiel, Charles E.	27,344
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Deshmukh, Sudhir	33,677	Li, Kening	44,872
Dobson, Kevin S.	40,296	Magee, Thomas H.	27,355
Duffy, Roseanne R.	33,869	Mayer, Nancy S.	29,190
Edwards, Mark A.	39,542	Medwick, George M.	27,456
Estrin, Barry	26,452	Morrissey, Bruce W.	30,663
Evans, Craig H.	31,825	Rizzo, Thomas M.	41,272
Fair, Tamera L.	35,867	Santopietro, Lois A.	36,264
Feltham, S. Neil	36,506	Schaeffer, Andrew L.	33,605
Floyd, Linda Axamothy	33,692	Sebree, Chyrra J.	45,348
Frank, George A.	27,636	Shafer, Robert J.	24,437
Golian, Andrew G.	25,293	Shay, Lucas K.	34,724
Gorman, Thomas W.	31,959	Shipley, James E.	32,003
Gould, David J.	25,338	Siegehl, Barbara C.	30,684
Griffiths, John E.	32,647	Simmott, Jessica M.	34,015
Hamby, Jane O.	32,872	Steinberg, Thomas W.	37,013
Hamby, William H.	31,521	Stevenson, Robert B.	26,039
Heiser, David E.	31,366	Strickland, Frederick D.	39,041
Hendrickson, John S.	30,847	Tessari, Joseph A.	32,177
Jones, Brian C.	37,857	Tulloch, Rebecca W.	36,297
Joung, J. Kenneth	41,881	Walker, P. Michael	32,602
Katz, Elliott A.	26,396	Wang, Chen	38,650

The undersigned ratifies fully all actions already taken by the above-named individuals in accordance with the authority granted hereby.

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By: Vernon R. Rice
Vernon R. Rice
Vice President and Assistant General Counsel

Date: 7/17/2006

DECLARATION and POWER OF ATTORNEY

As a below-named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

PHOTORESISTS AND PROCESSES FOR MICROLITHOGRAPHY

the specification of which is attached hereto unless the following box is checked:

☒ was filed on **26 OCTOBER 1999** as U.S. Application No. _____ or PCT International Application No. **PCT/US99/25106**, and was amended on _____ (if applicable).

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above.

I acknowledge the duty to disclose information which is known to me to be material to patentability as defined in 37 CFR § 1.56.

I hereby claim foreign priority benefits under 35 U.S.C. § 119(a)-(d) or § 365(b) of any foreign application(s) for patent or inventor's certificate, or § 365(a) of any PCT International application which designated at least one country other than the United States, listed below and have also identified below, by checking the box, any foreign application for patent or inventor's certificate, or PCT International application having a filing date before that of the application on which priority is claimed.

Application No.	Country	Filing Date	Priority Claimed (Yes/No)

I hereby claim the benefit under 35 U.S.C. § 119(e) of any United States Provisional Application(s) listed below.

U.S. Provisional Application No.

U.S. Filing Date

60/105,789

27 OCTOBER 1998

I hereby claim the benefit under 35 U.S.C. § 120 of any United States application(s), or § 365(c) of any PCT International Application designating the United States, listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application or PCT International Application in the manner provided by the first paragraph of 35 U.S.C. § 112, I acknowledge the duty to disclose information which is known to me to be material to patentability as defined in 37 CFR § 1.56 which became available between the filing date of the prior application and the national or PCT International filing date of this application.

Application No.	Filing Date	Status (patented, pending or abandoned)

POWER OF ATTORNEY: I hereby appoint the following attorney(s) and/or agent(s) the power to prosecute this application and transact all business in the Patent and Trademark Office connected therewith:Name: **THOMAS H. MAGEE**Registration No.: **27,355**

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I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

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☐ Additional Inventors are being named on separately numbered sheets attached hereto.